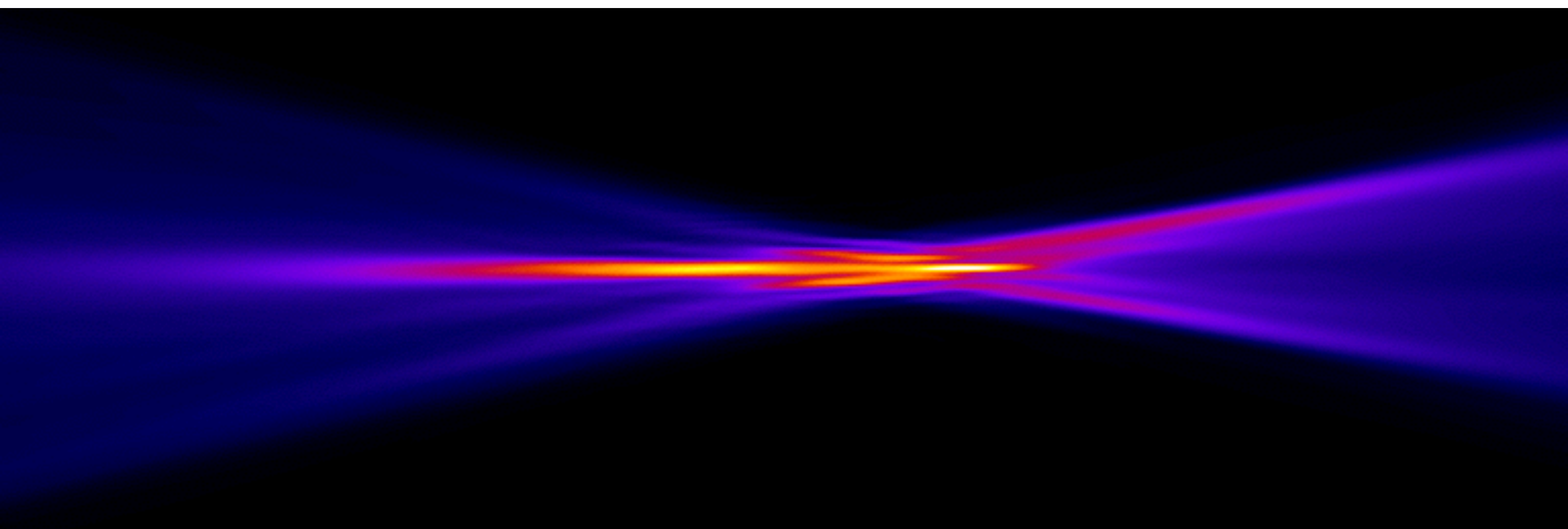


# XFEL Science with Nanobeams

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# Collaboration



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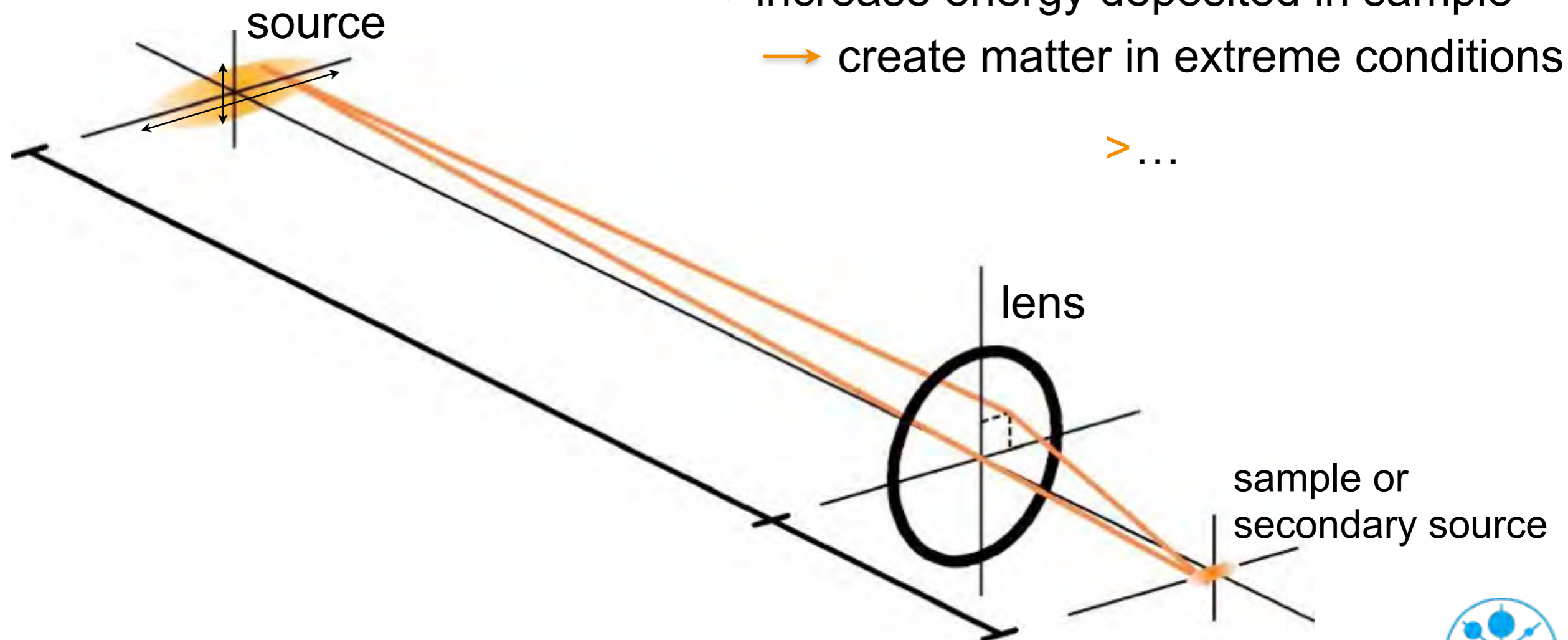
H.J. Lee, R. Nagler,  
E. C. Galtier, U. Zastra,  
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B. Arnold  
LCLS, Menlo Park, USA

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European XFEL



# Focusing Hard X-Ray FEL Pulses

- > increase fluence for imaging
  - resolution determined by fluence on sample
- > increase intensity on sample
  - induce non-linear optical effects
- > increase energy deposited in sample
  - create matter in extreme conditions

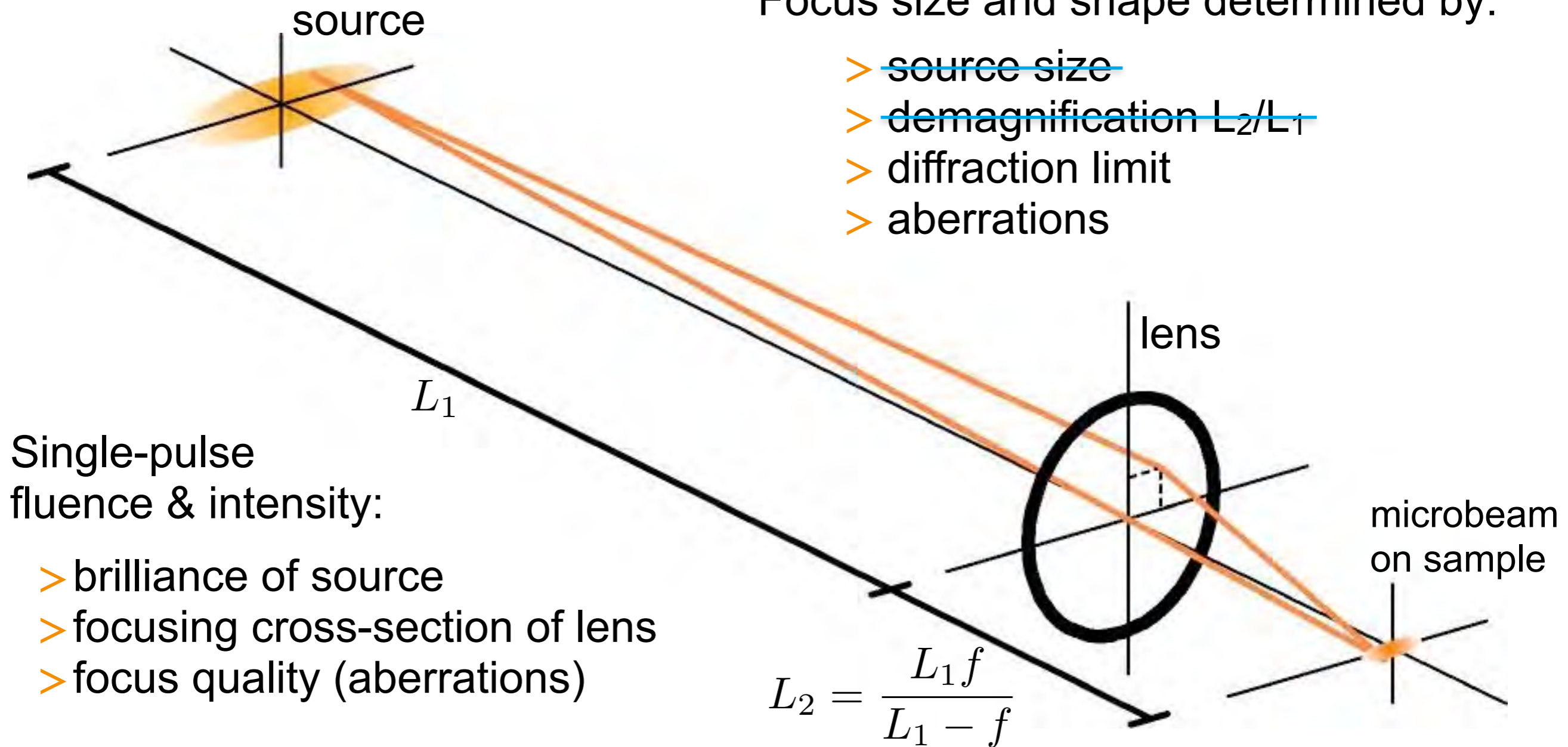


# Diffraction-Limited Focusing at XFEL Source

XFEL beam: High degree of transverse coherence

Focus size and shape determined by:

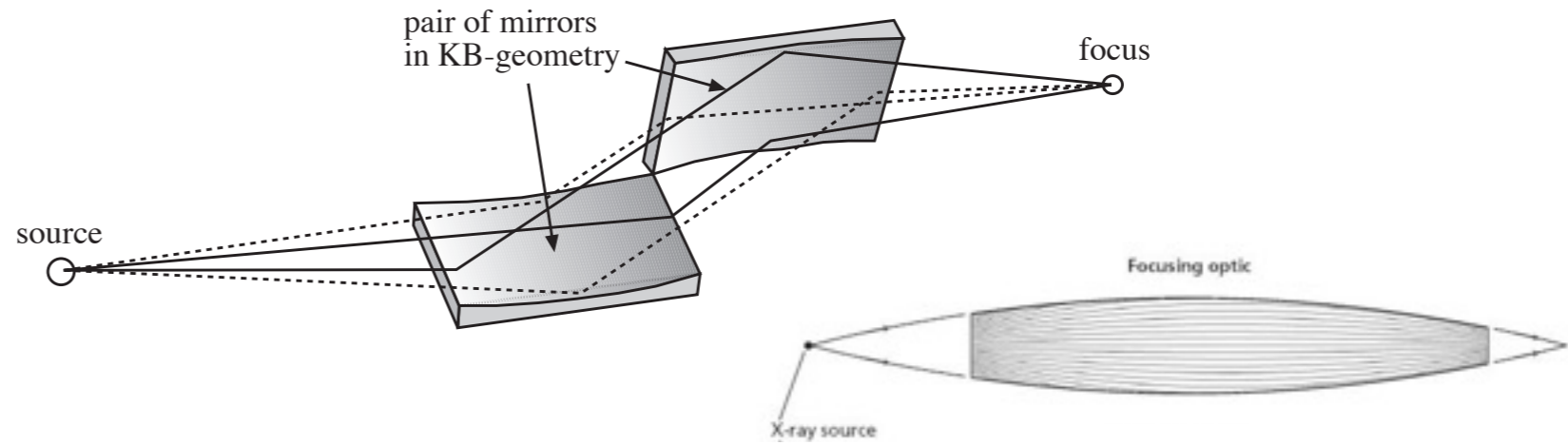
- > ~~source size~~
- > ~~demagnification  $L_2/L_1$~~
- > diffraction limit
- > aberrations



# Nanofocusing Optics

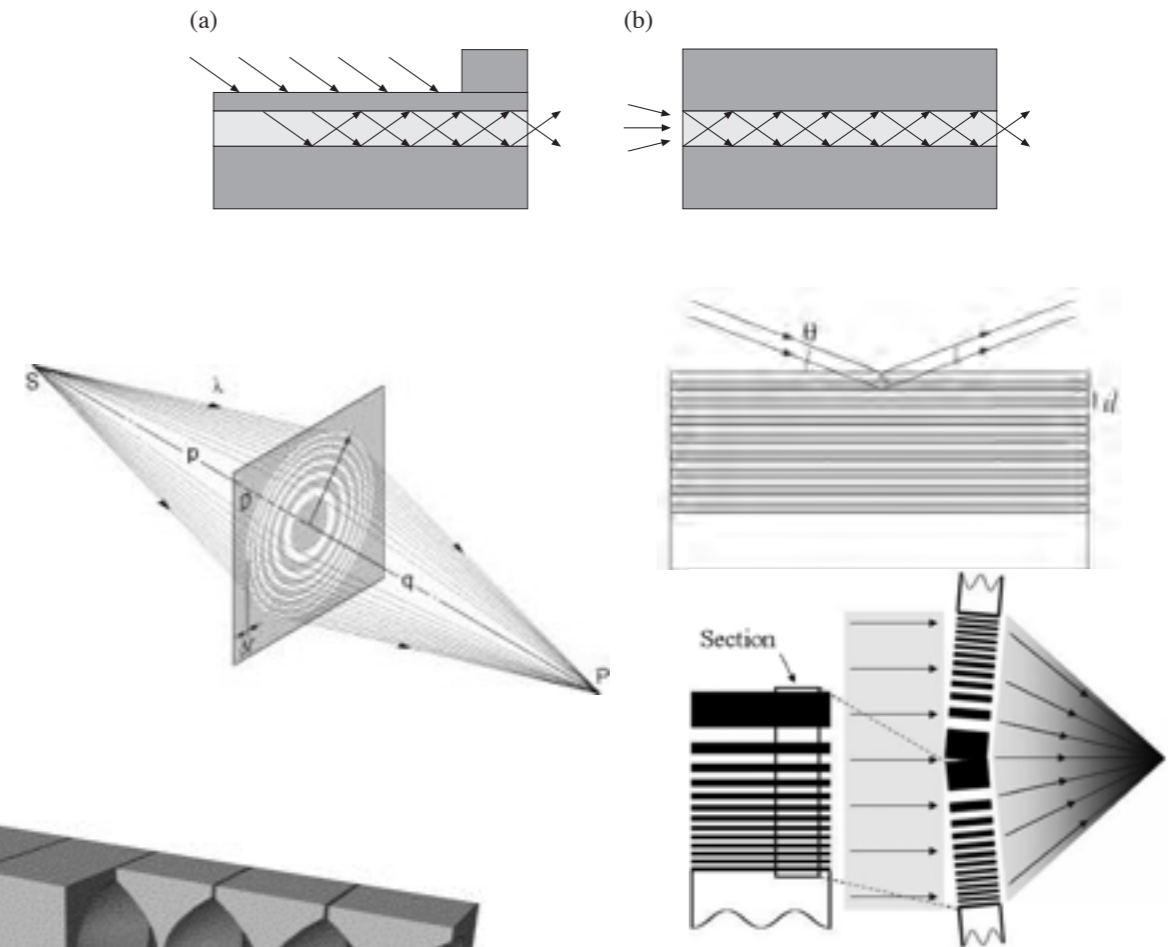
## reflection:

- > mirrors (25 nm)
- > capillaries
- > wave guides (~10 nm)



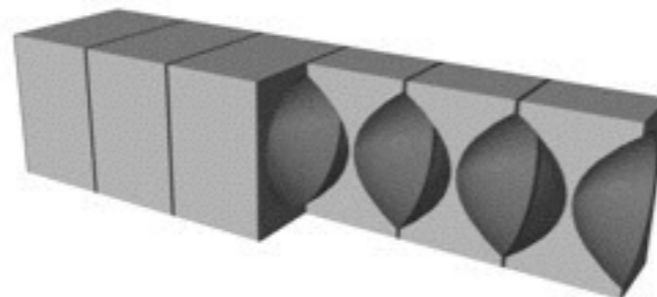
## diffraction:

- > Fresnel zone plates (~20 nm)
- > multilayer mirrors (7 nm)
- > multilayer Laue lenses (16 nm)
- > bent crystals



## refraction:

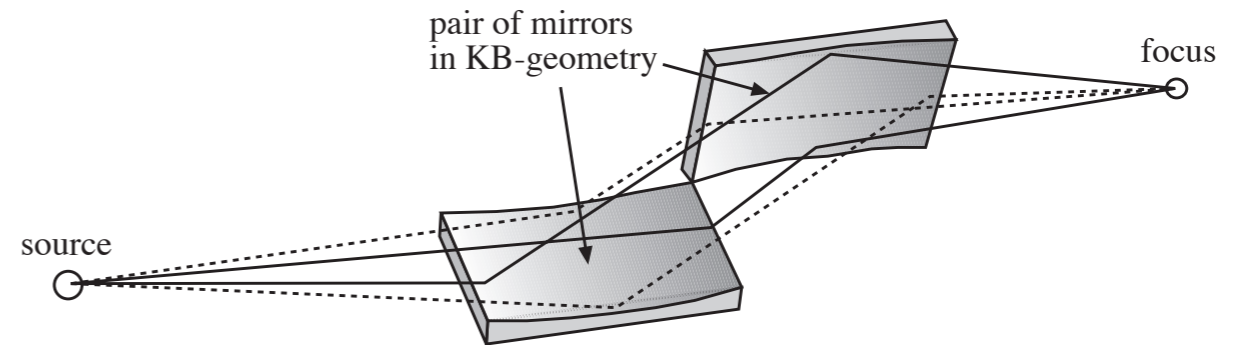
- > lenses (43 nm, 18 nm)



# Nanofocusing Optics at XFEL

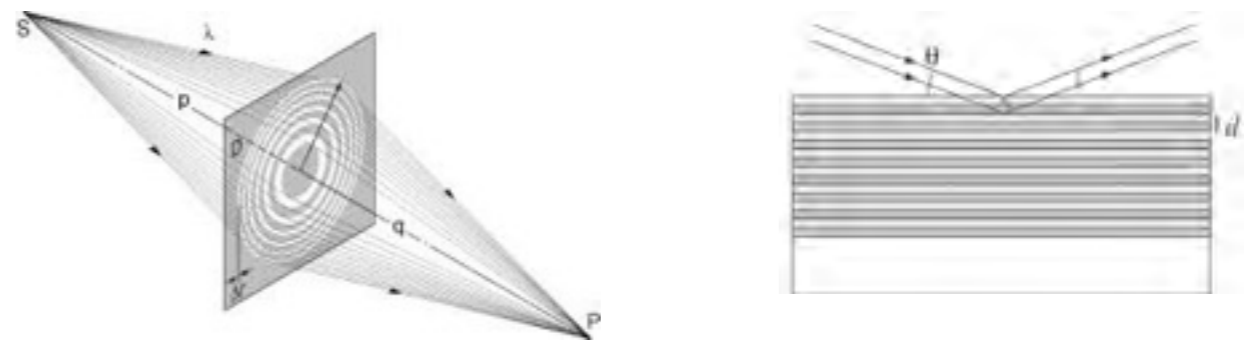
## reflection:

- > mirrors (50 nm)
- > ~~capillaries~~
- > ~~wave guides~~



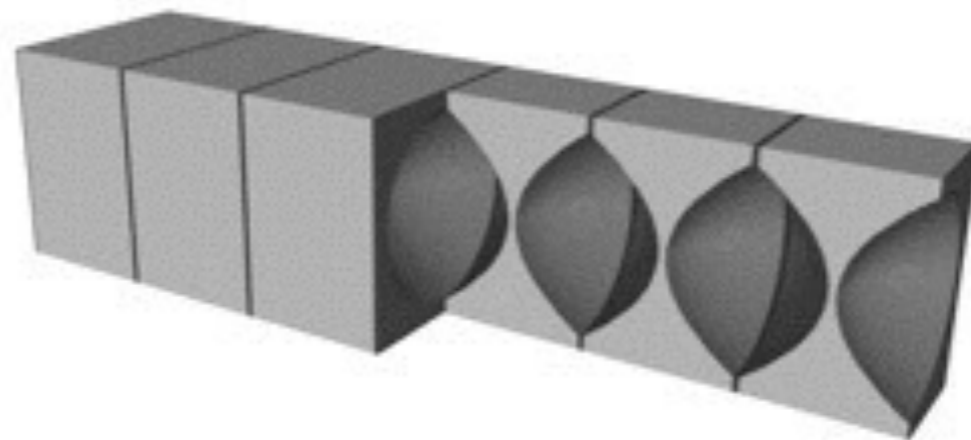
## diffraction:

- > Fresnel zone plates (~200 nm)
- > multilayer mirrors
- > ~~multilayer Laue lenses~~
- > ~~bent crystals~~



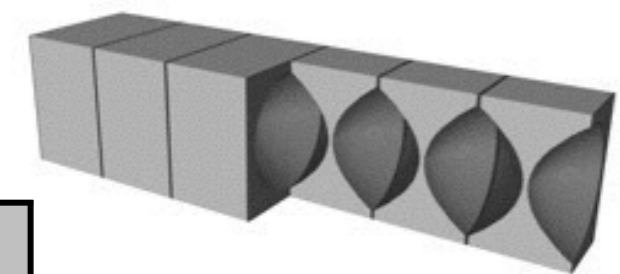
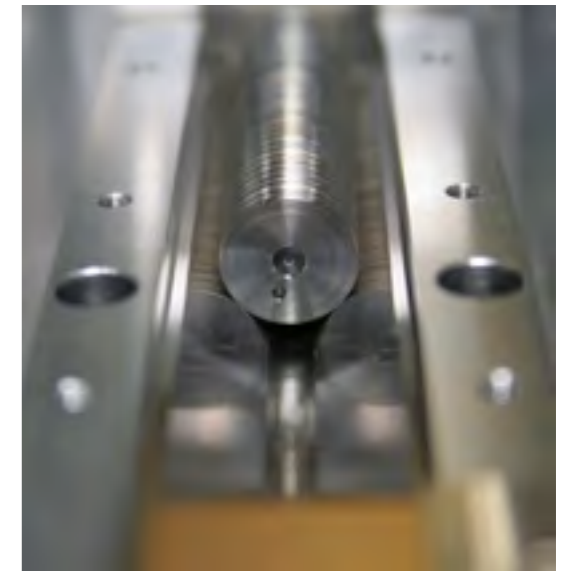
## refraction:

- > lenses (125 nm)



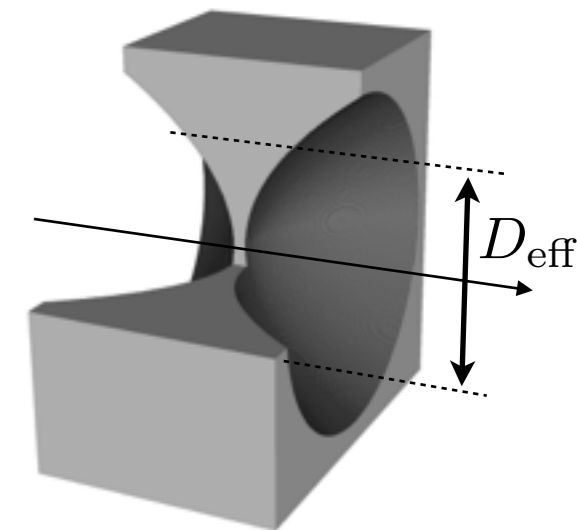
# Beryllium Compound Refractive Lenses

- > first realized in 1996 (Snigirev et al.)
- > a variety of refractive lenses have been developed since
- > applied in full-field imaging and scanning microscopy
- > Beryllium: withstands single XFEL pulses
- > Disadvantage: chromaticity



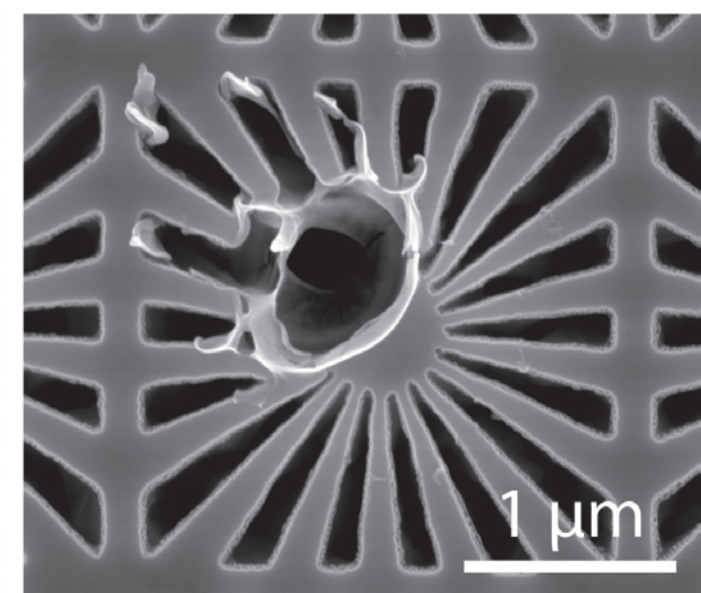
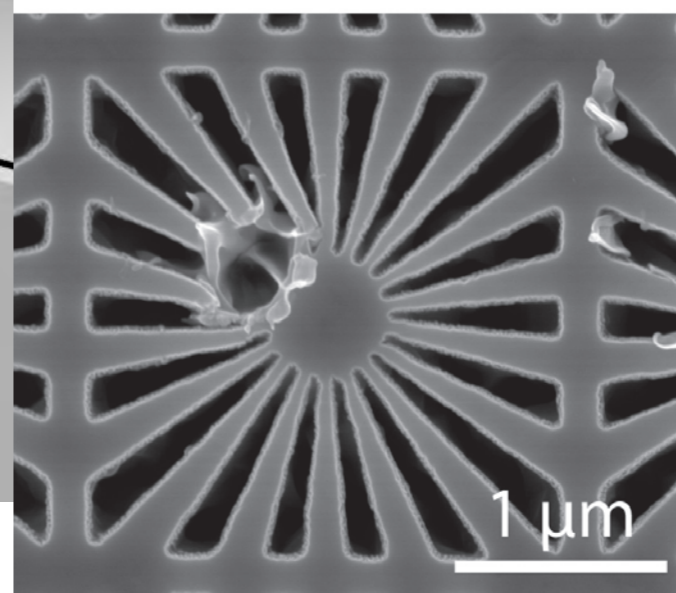
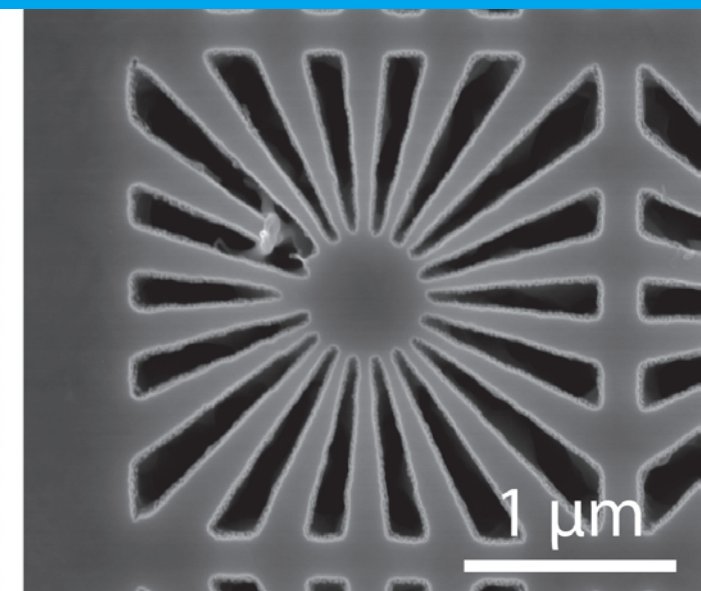
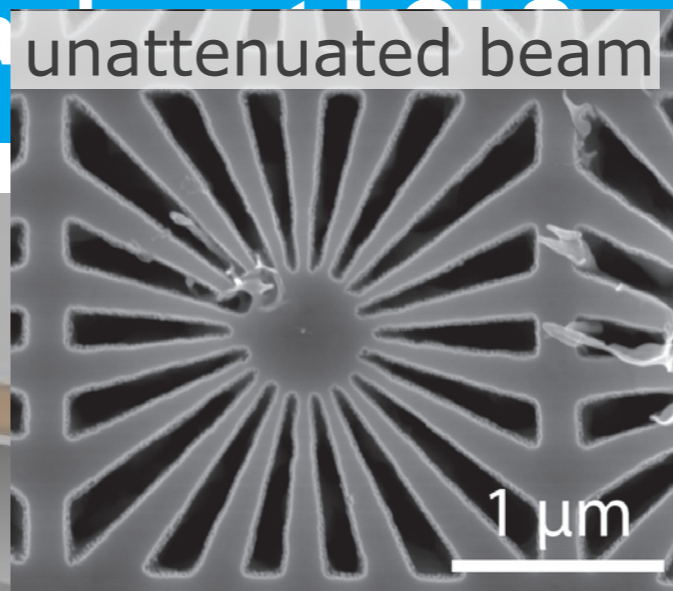
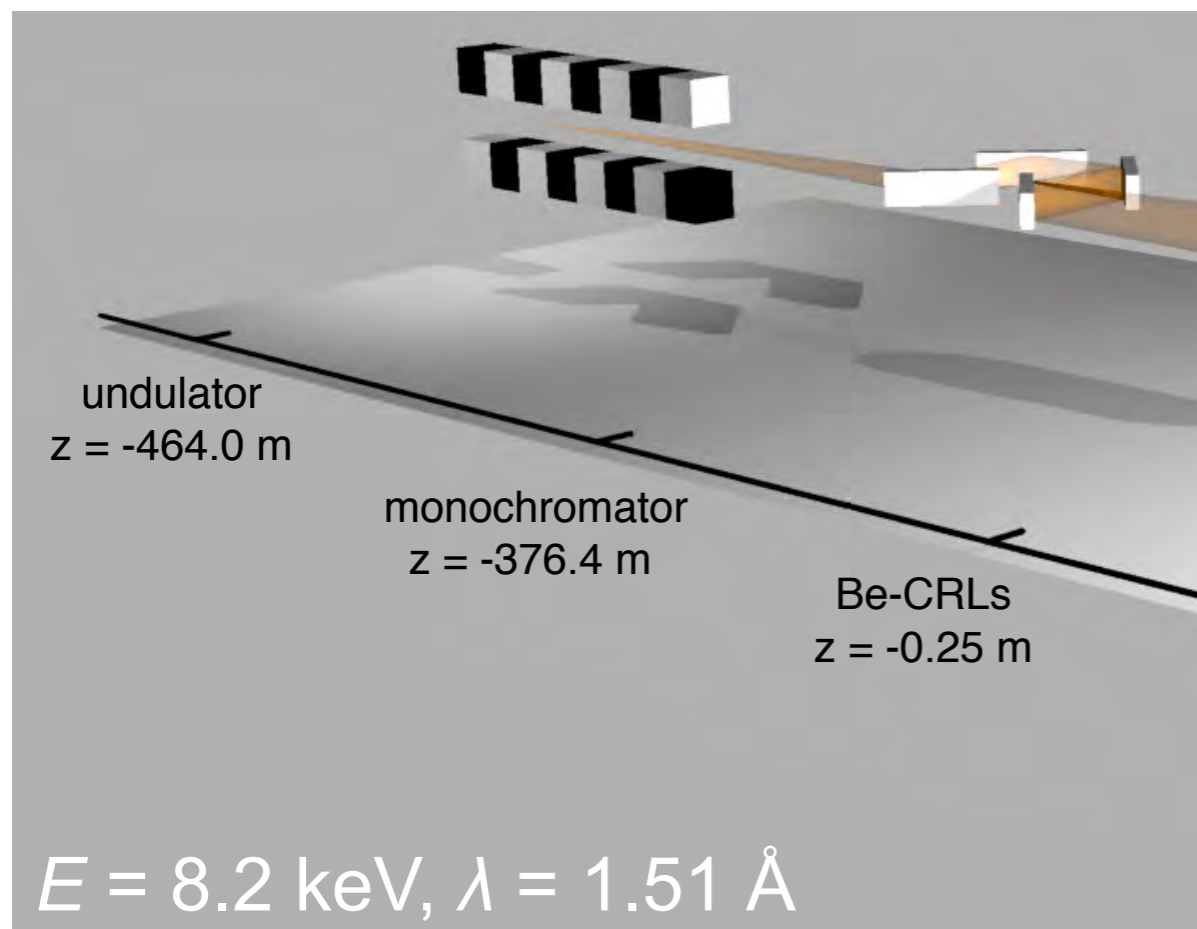
Example parameters for LCLS MEC:

E [keV]	f [mm]	N	NA [mrad]	$d_t$ [nm]	flux [ph/pulse]	power density [W/cm <sup>2</sup> ]	gain
	200	24	0.70	82	$3.3 \cdot 10^{10}$	$1.33 \cdot 10^{19}$	$7.1 \cdot 10^6$
8	300	16	0.54	108	$4.7 \cdot 10^{10}$	$1.09 \cdot 10^{19}$	$6.6 \cdot 10^6$
	400	12	0.43	133	$6.0 \cdot 10^{10}$	$9.17 \cdot 10^{18}$	$6.0 \cdot 10^6$
9	200	31	0.73	71	$3.5 \cdot 10^{10}$	$2.12 \cdot 10^{19}$	$1.0 \cdot 10^7$
	300	20	0.54	95	$5.1 \cdot 10^{10}$	$1.73 \cdot 10^{19}$	$9.3 \cdot 10^6$
	400	15	0.44	118	$6.3 \cdot 10^{10}$	$1.38 \cdot 10^{19}$	$8.4 \cdot 10^6$

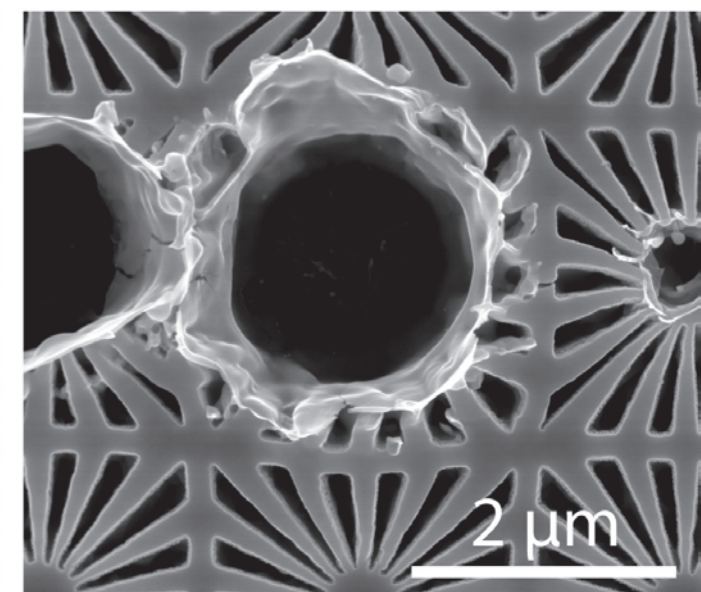
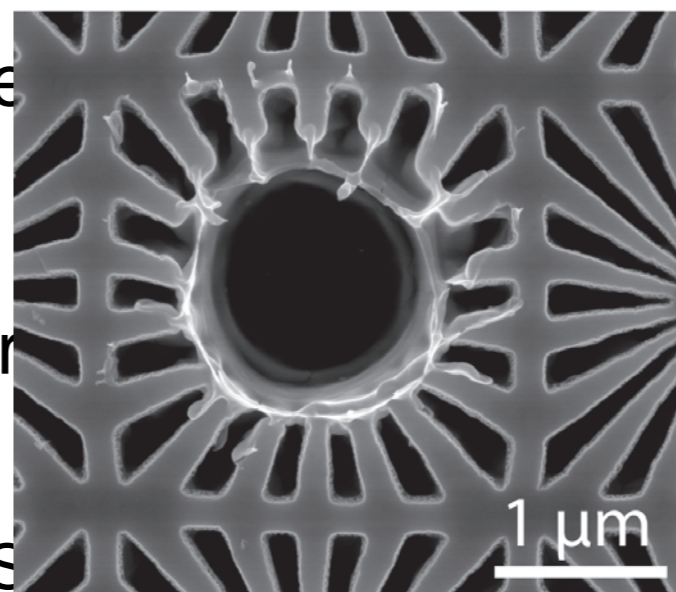


parameters without prefocusing, pulse length: 60 fs

# Nanofocusing and Nanoimaging



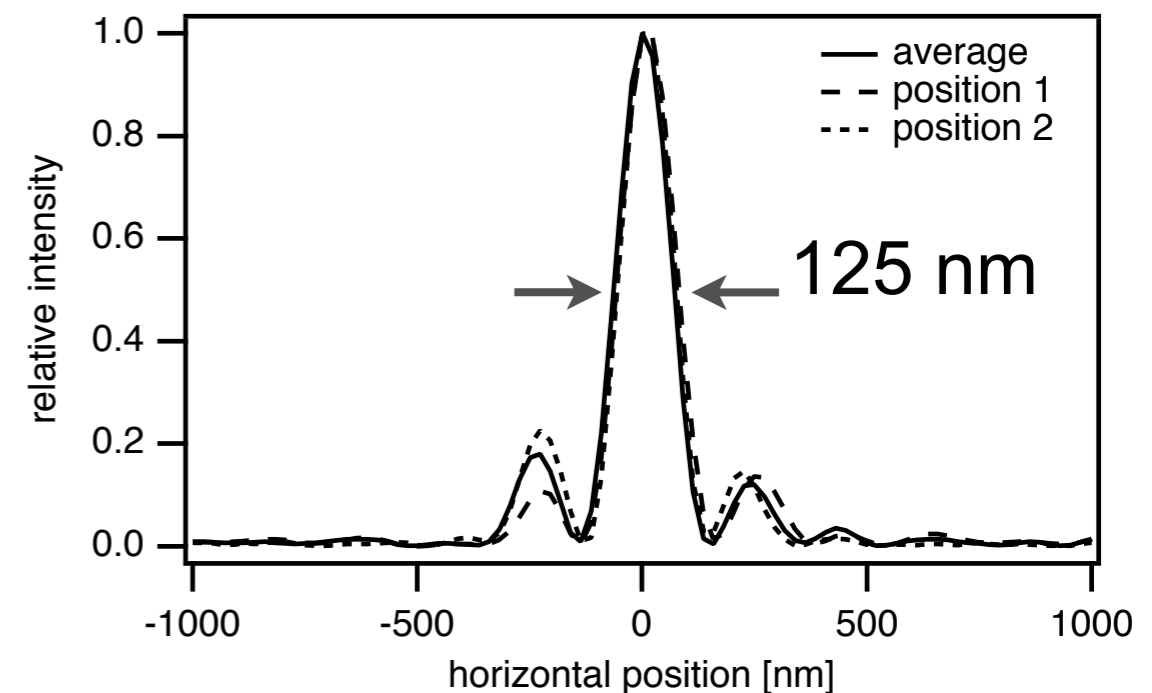
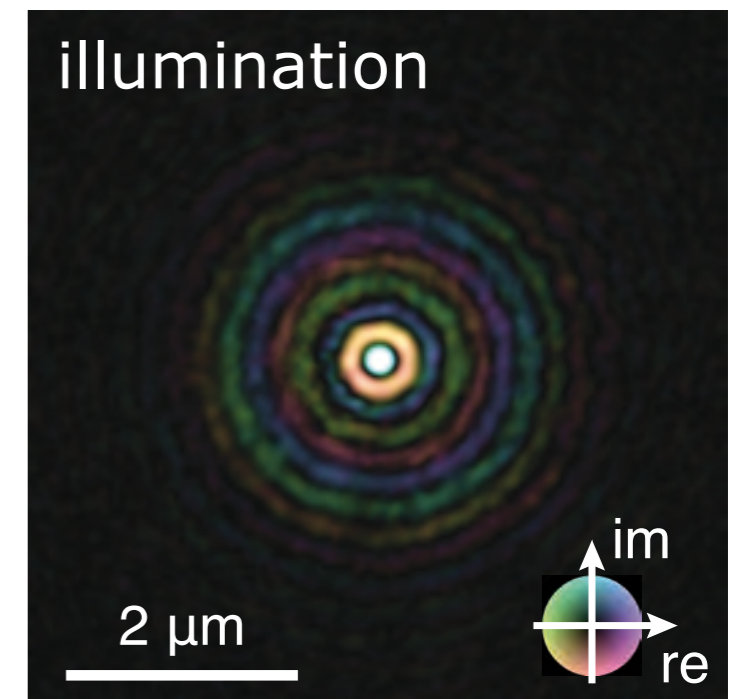
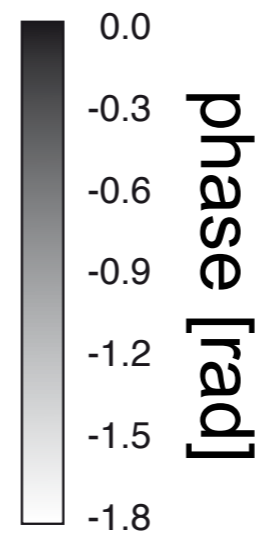
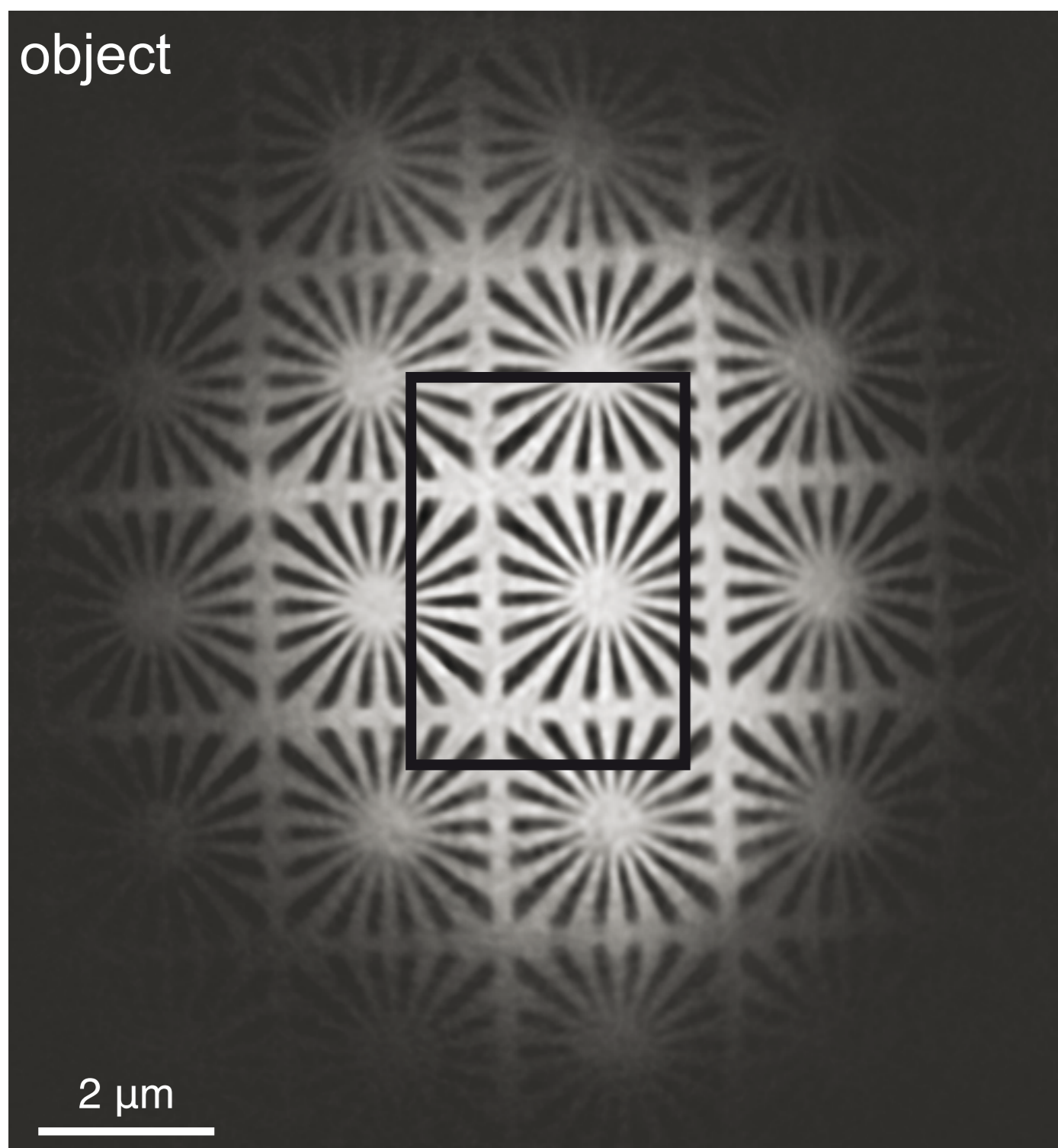
- > Nanofocusing by Be CRLs
  - generate nanobeam for near-field
- > Characterization by ptychography
  - determine full caustic and aberrations



A. Schropp, et al., S



# Ptychographic Reconstruction

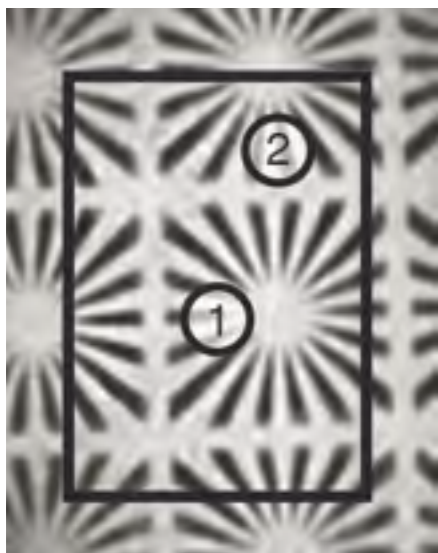


A. Schropp, et al., Sci. Rep. **3**, 1633 (2013).

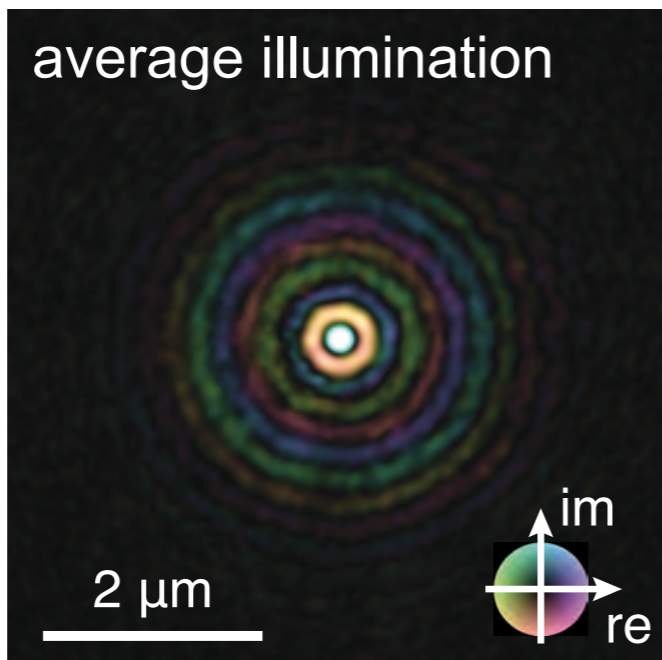


# Illumination: Single-Shot Refinement

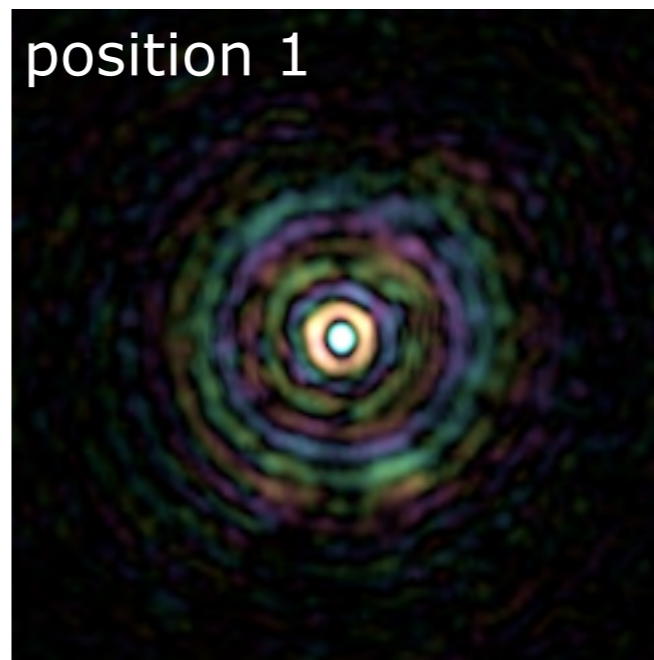
object:



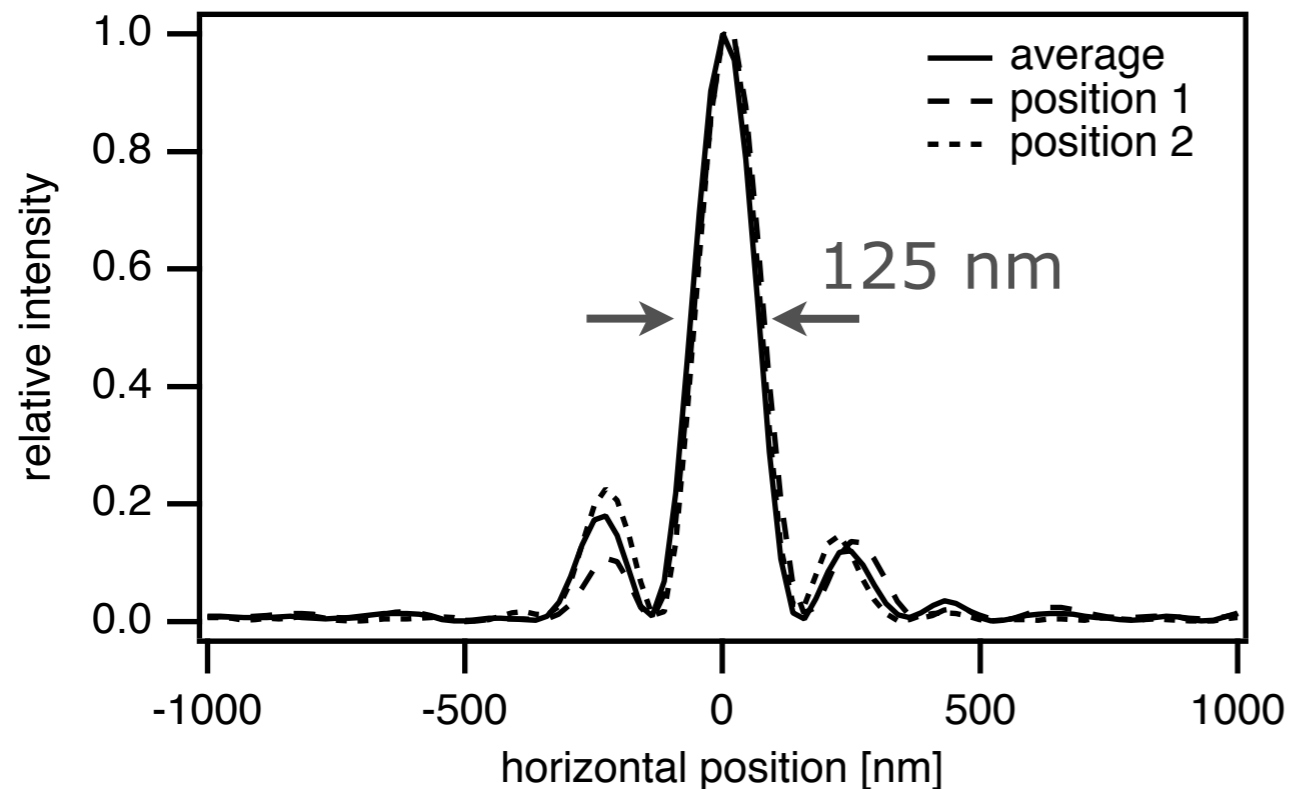
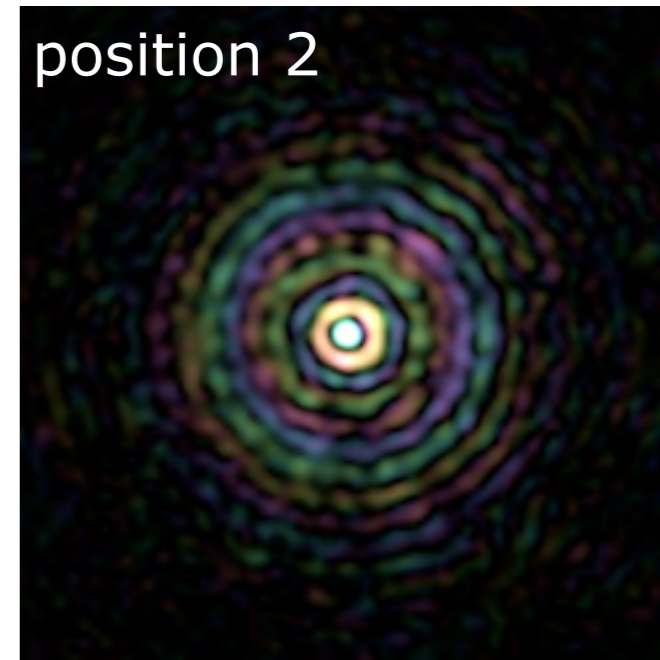
average illumination



position 1



position 2



Refine single shot illumination:

- > fixed, reconstructed object
- > individual diffraction pattern
- *a-posteriori* reconstruction of illumination!

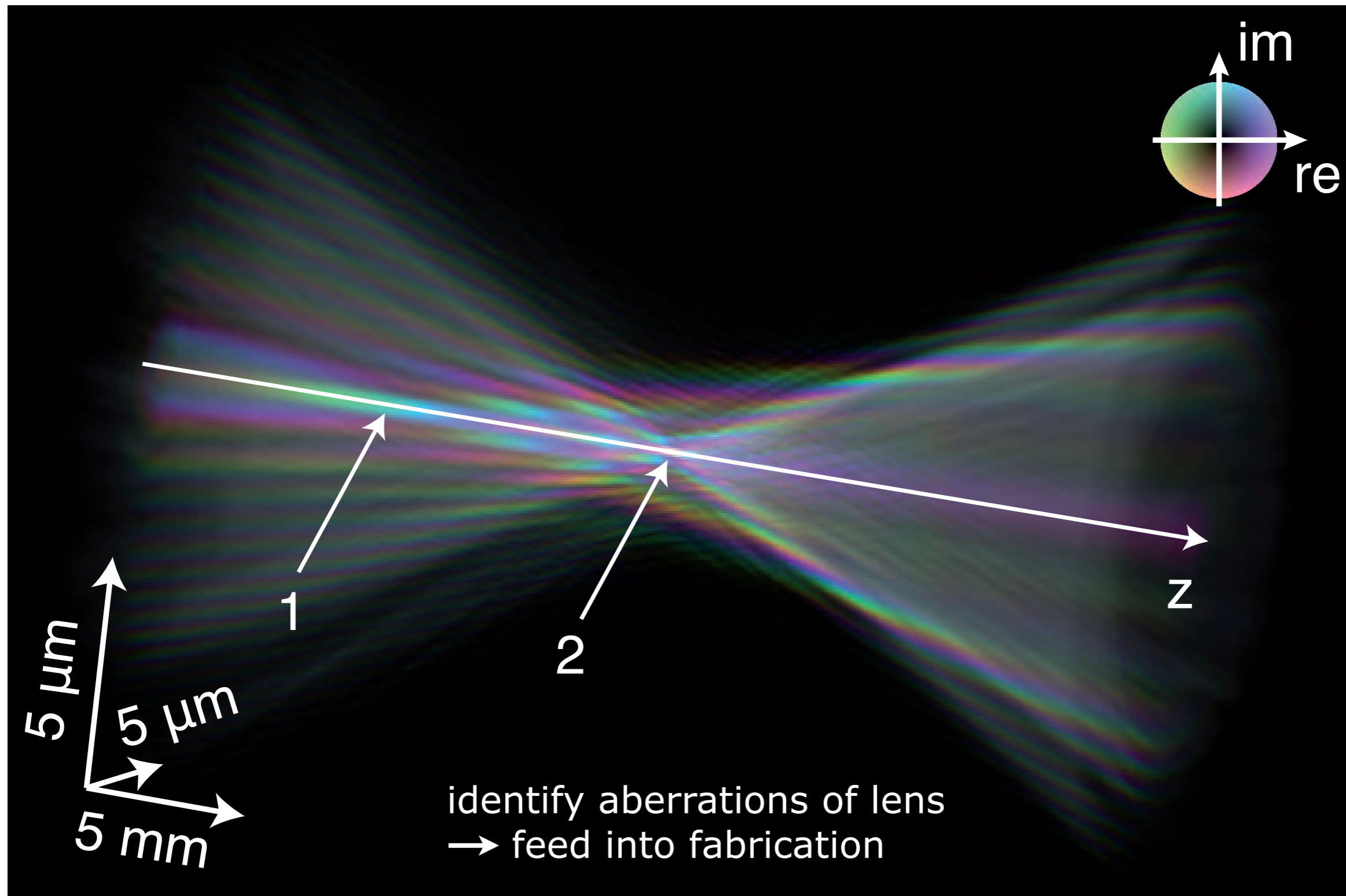
In future:

- derive non-invasive single-shot diagnostics

A. Schropp, et al., Sci. Rep. **3**, 1633 (2013).



# Nanofocused LCLS Beam Profile



A. Schropp, et al., Sci. Rep. **3**, 1633 (2013).

Christian G. Schroer | MID Workshop | 26. January 2015 | page 11

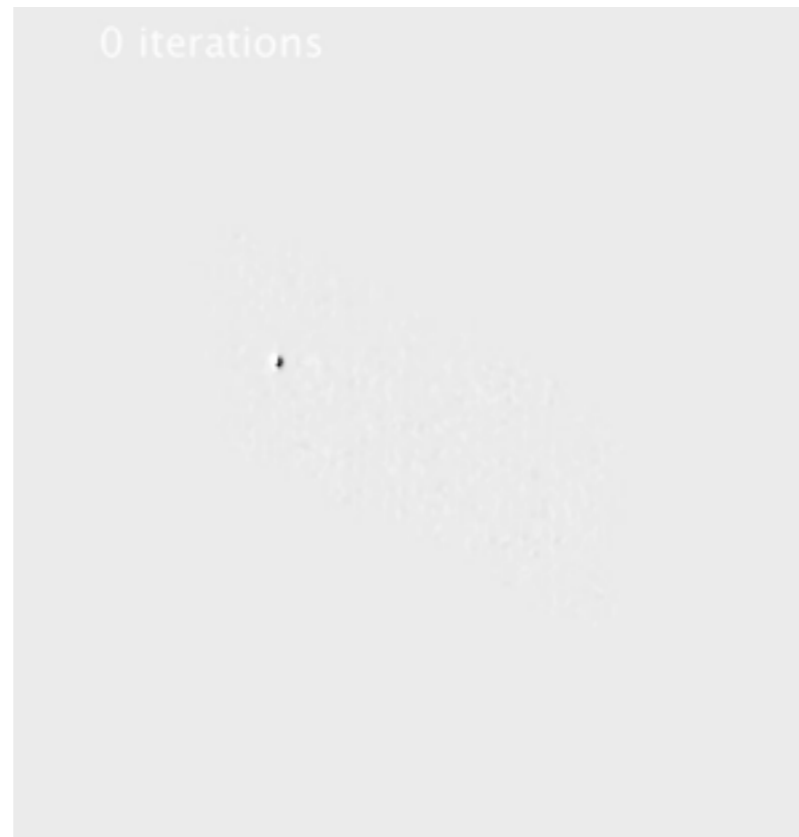
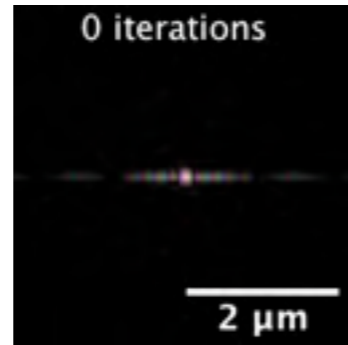


# Fast XFEL-Nanobeam Characterization

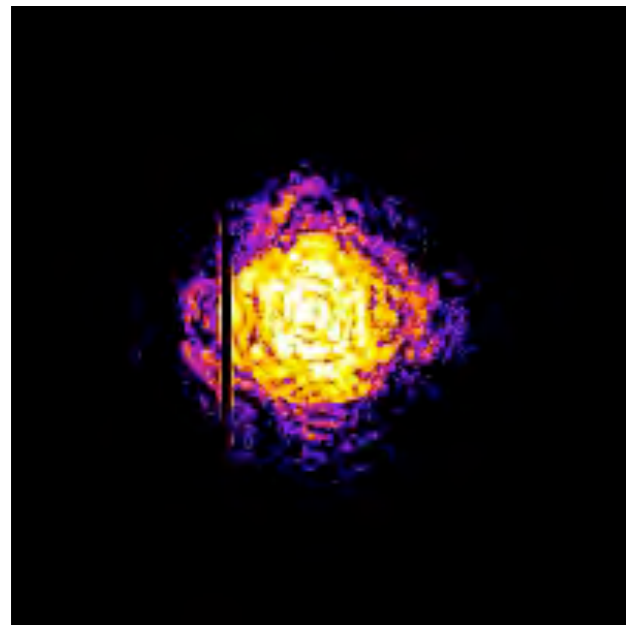
Example: Ptychography at 120 Hz (LCLS)



nanostructured sample  
(SEM image)

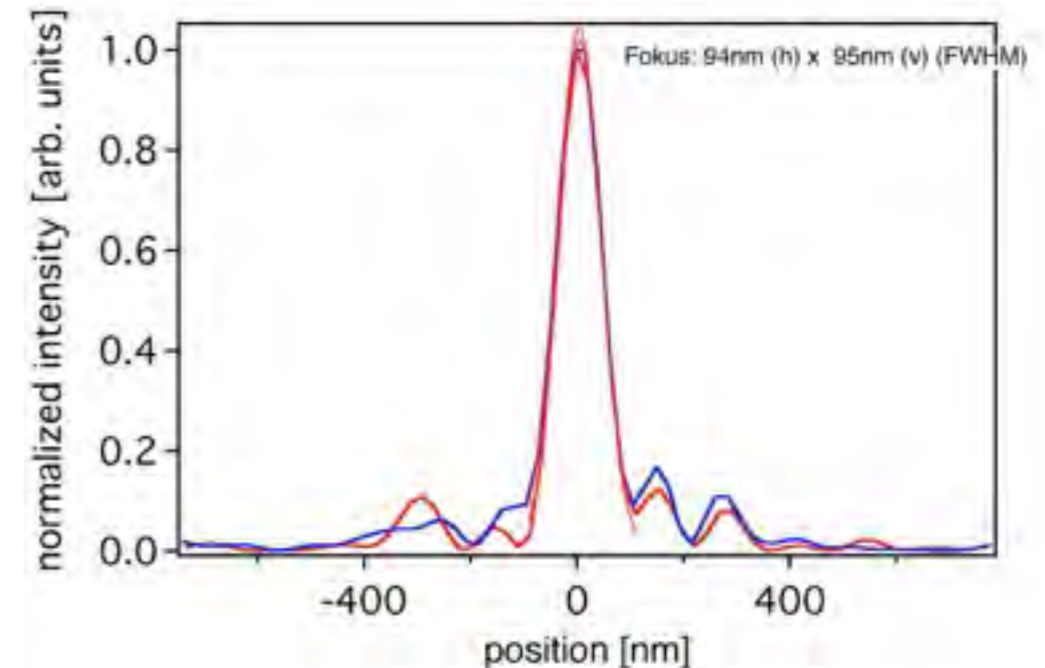


object reconstruction



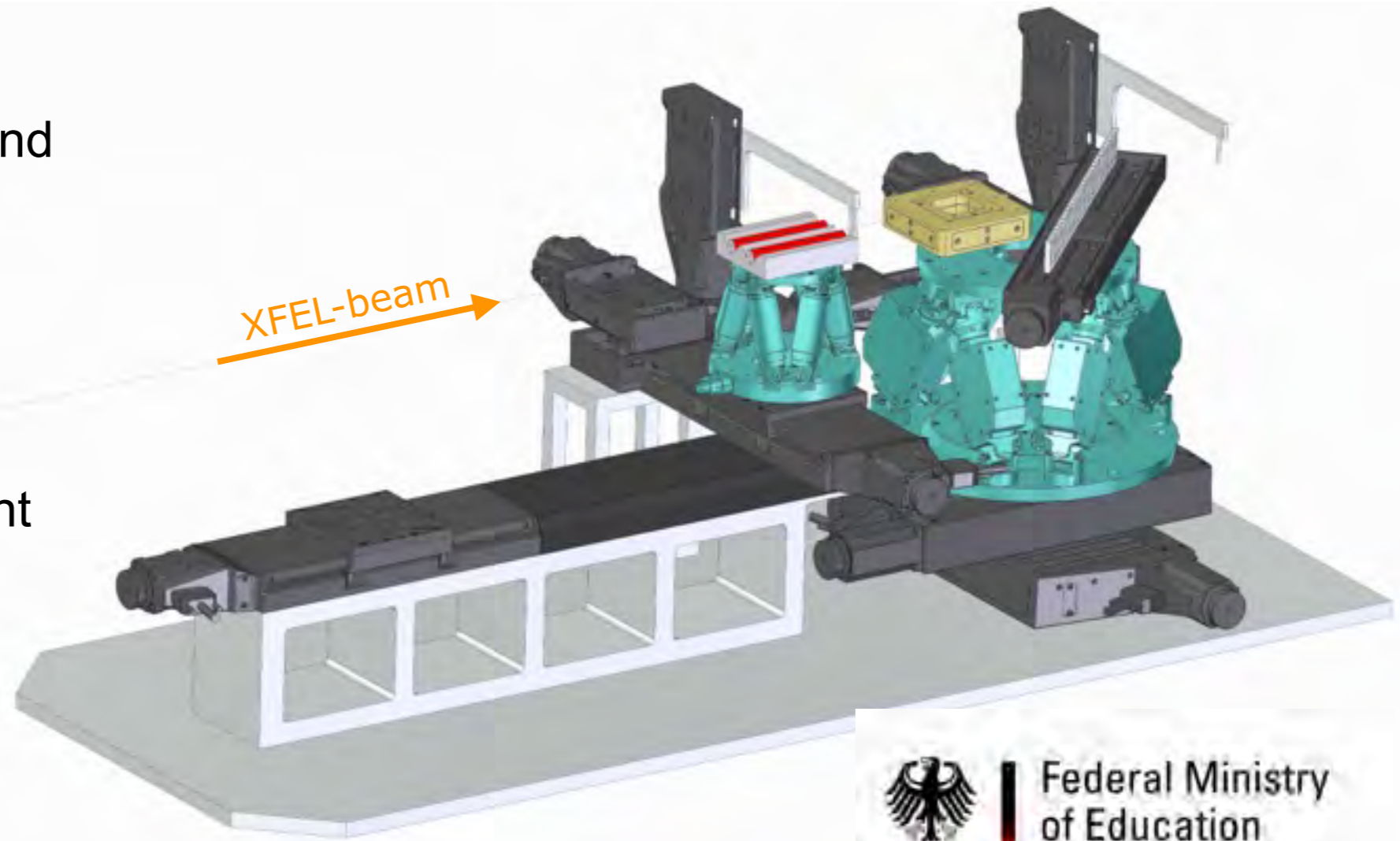
diffraction patterns

- > stack of 30 Be-CRLs,  $f = 170\text{mm}$
- > 2D-scan: 50 x 50 steps with a step size of 100 nm
- > theoretical focus size: 85nm (FWHM)
- > measured focus size: 95nm (FWHM)



# Dedicated Nanofocusing Setup for LCLS/MEC and MID

- > combines ptychography and near-field phase-contrast imaging
- > high stability
- > high positioning accuracy
- > hexapods for the alignment of Be-CRLs and sample
- > long travel range for the alignment of Be CRLs (FOV)
- > cleaning aperture after lens
- > beam stop
- > compact design in order to enable a fast experimental setup



Integration in MID at XFEL:

- > redesign lens stage to fit vacuum vessel
- > make use of sample stage

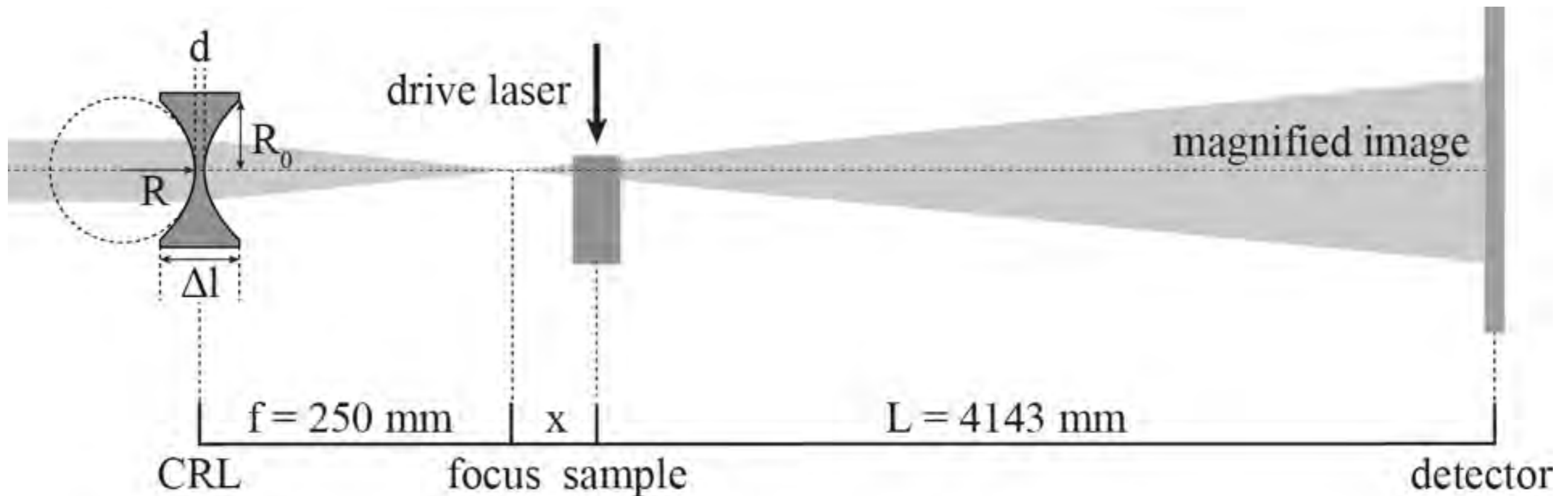


Federal Ministry  
of Education  
and Research

05 K13OD2

# Example: High Resolution X-Ray Imaging at LCLS

Method: magnifying phase contrast imaging



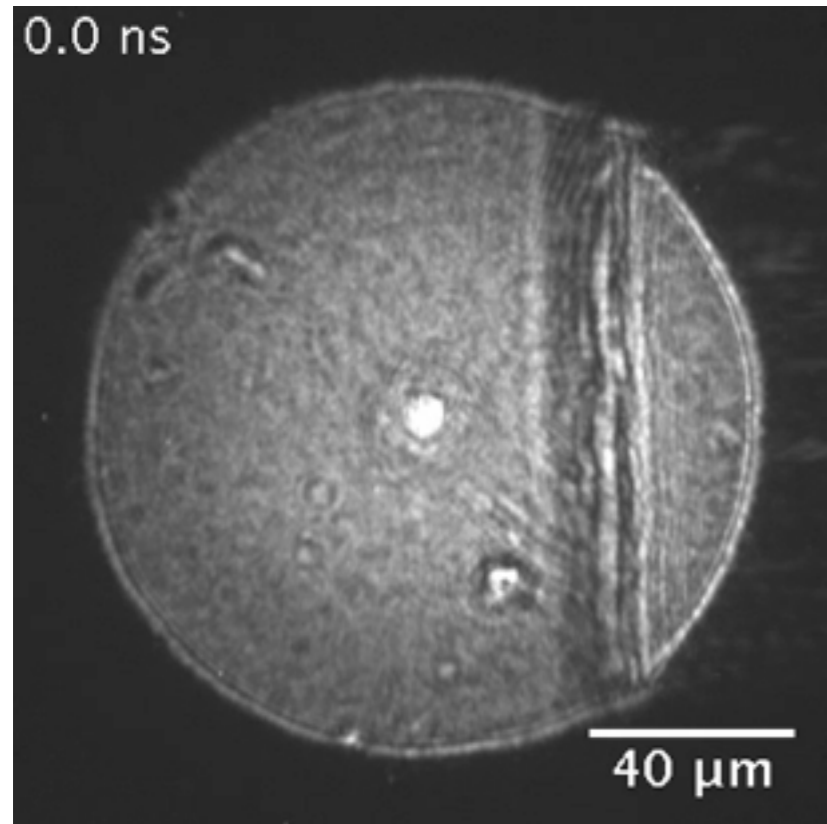
- > imaging with secondary point source: efficient use of fluence
- > phase contrast: for quantitative results, phase retrieval required

Alternatively:

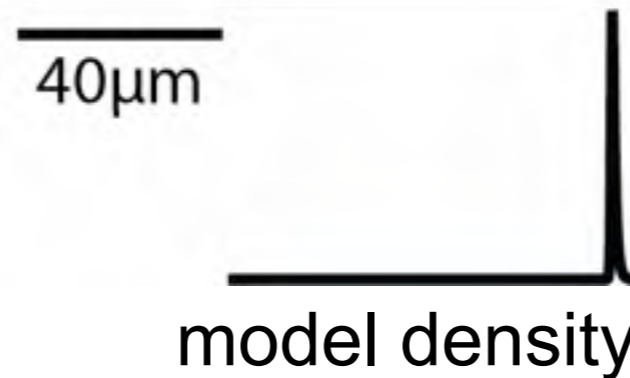
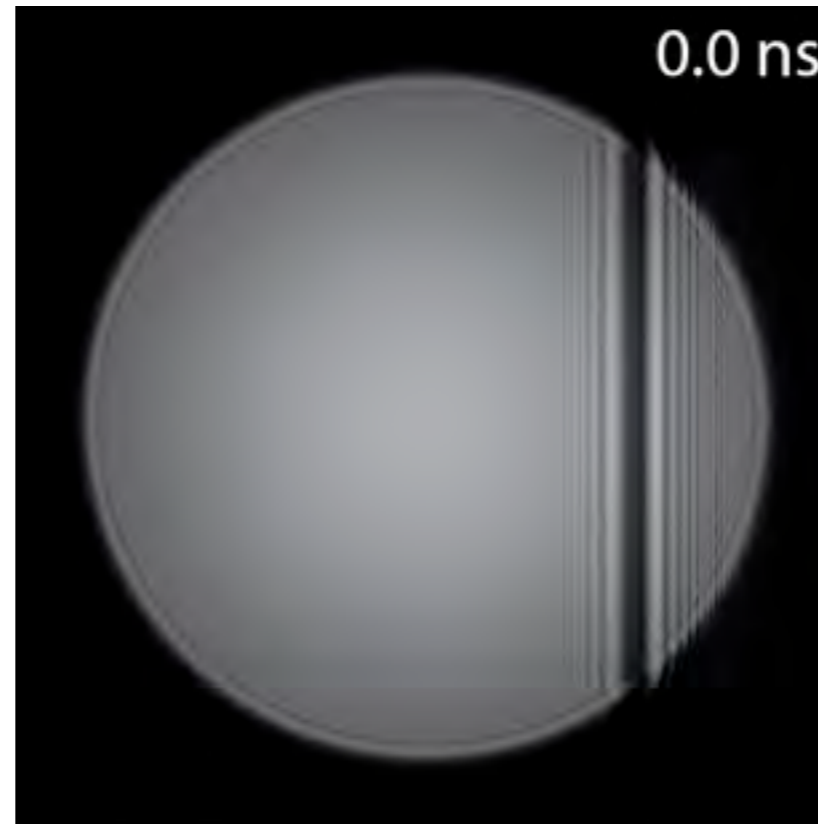
Time-resolved diffraction in focus of nanobeam

# Shockwaves in Diamond

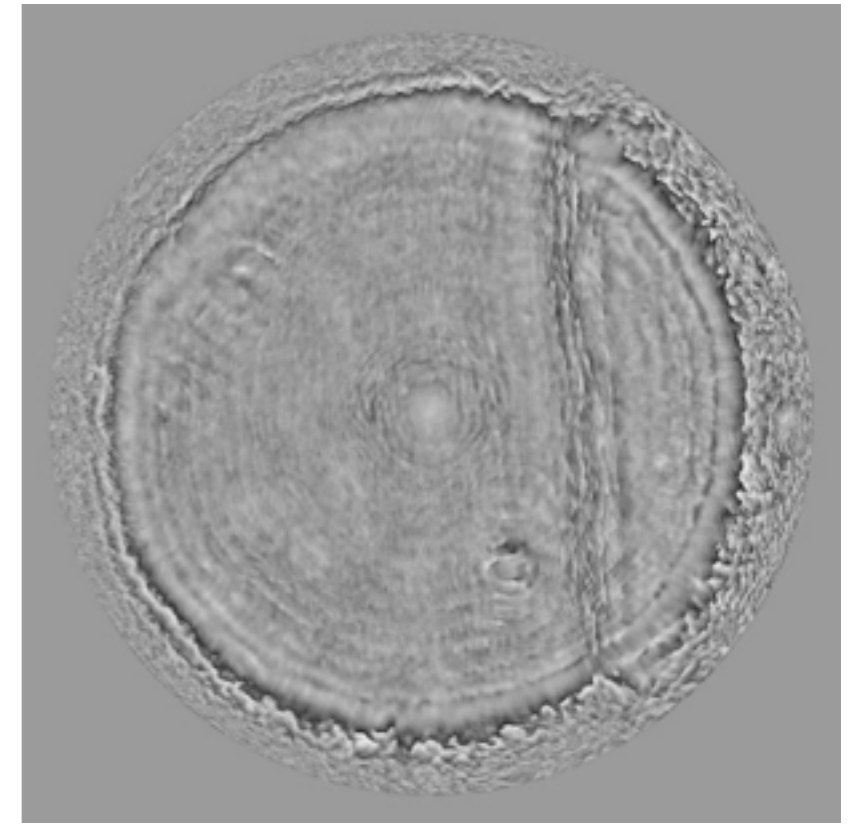
Diamond at high pressure and temperature



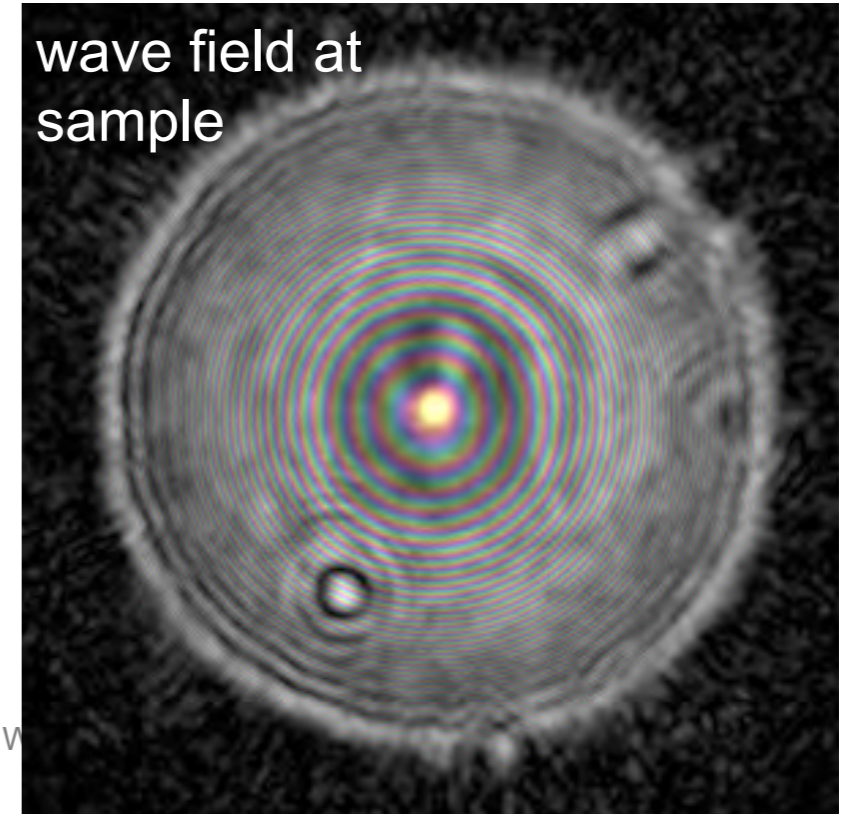
projection images



model density



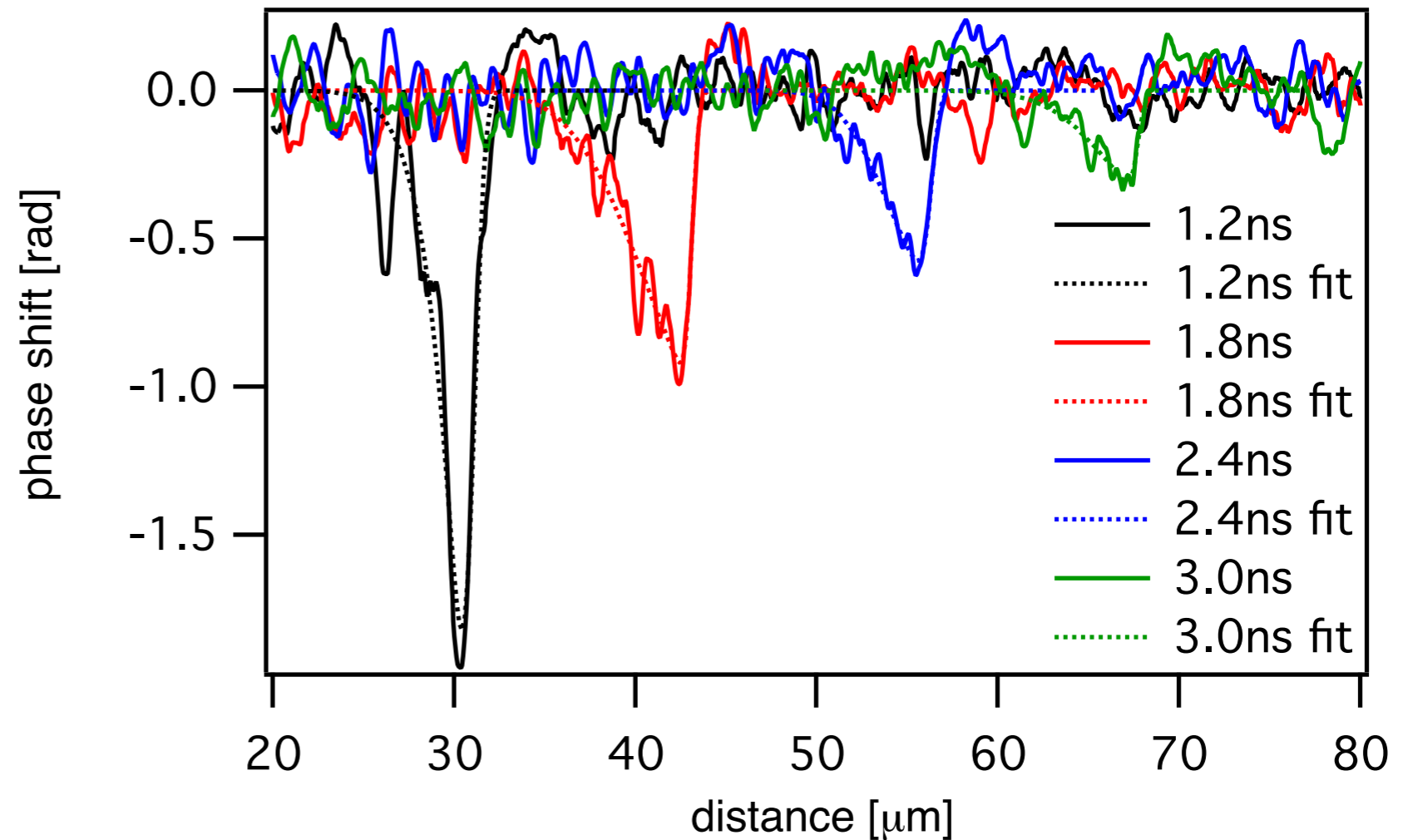
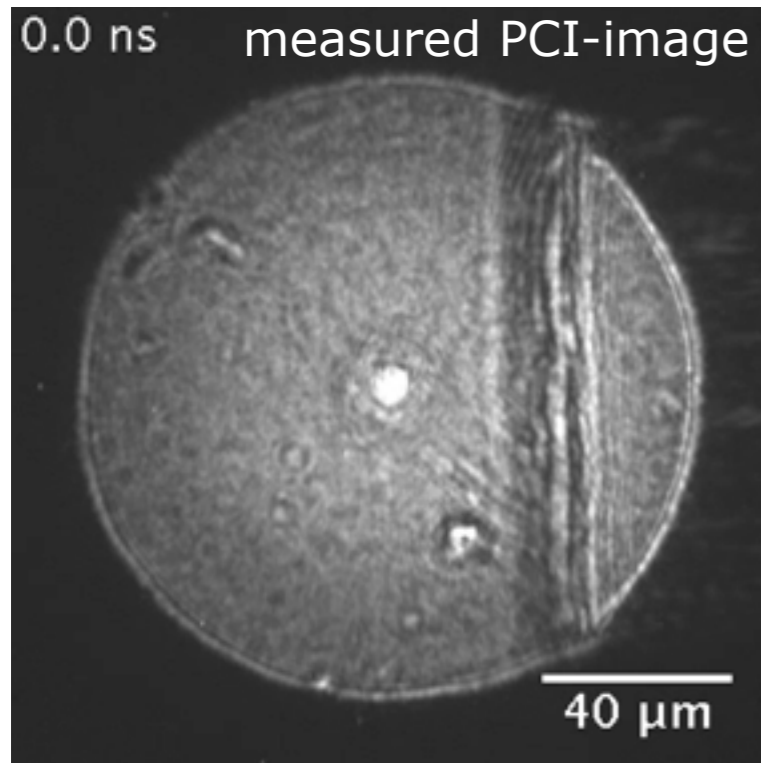
wave field at sample



- exposure time 50 fs
- 5 billion images per second (stop-trick movie)

A. Schropp, et al., unpublished.

# Elastic Wave in Diamond



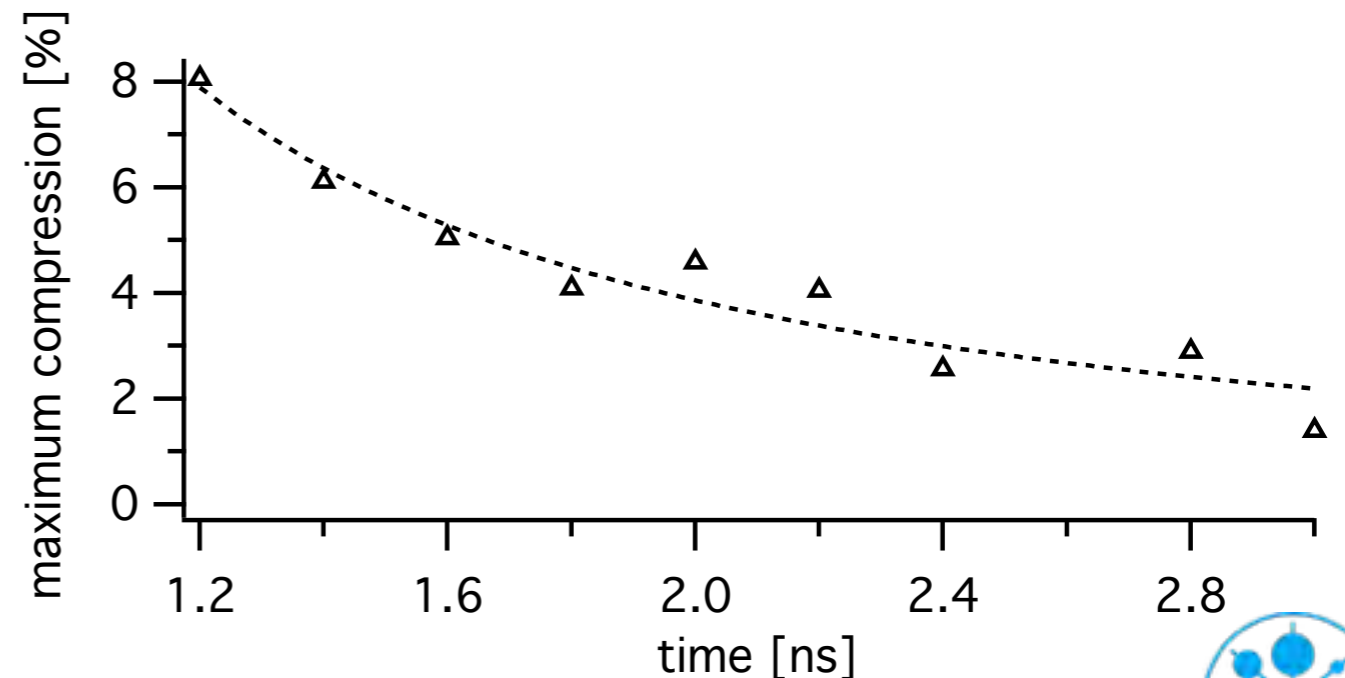
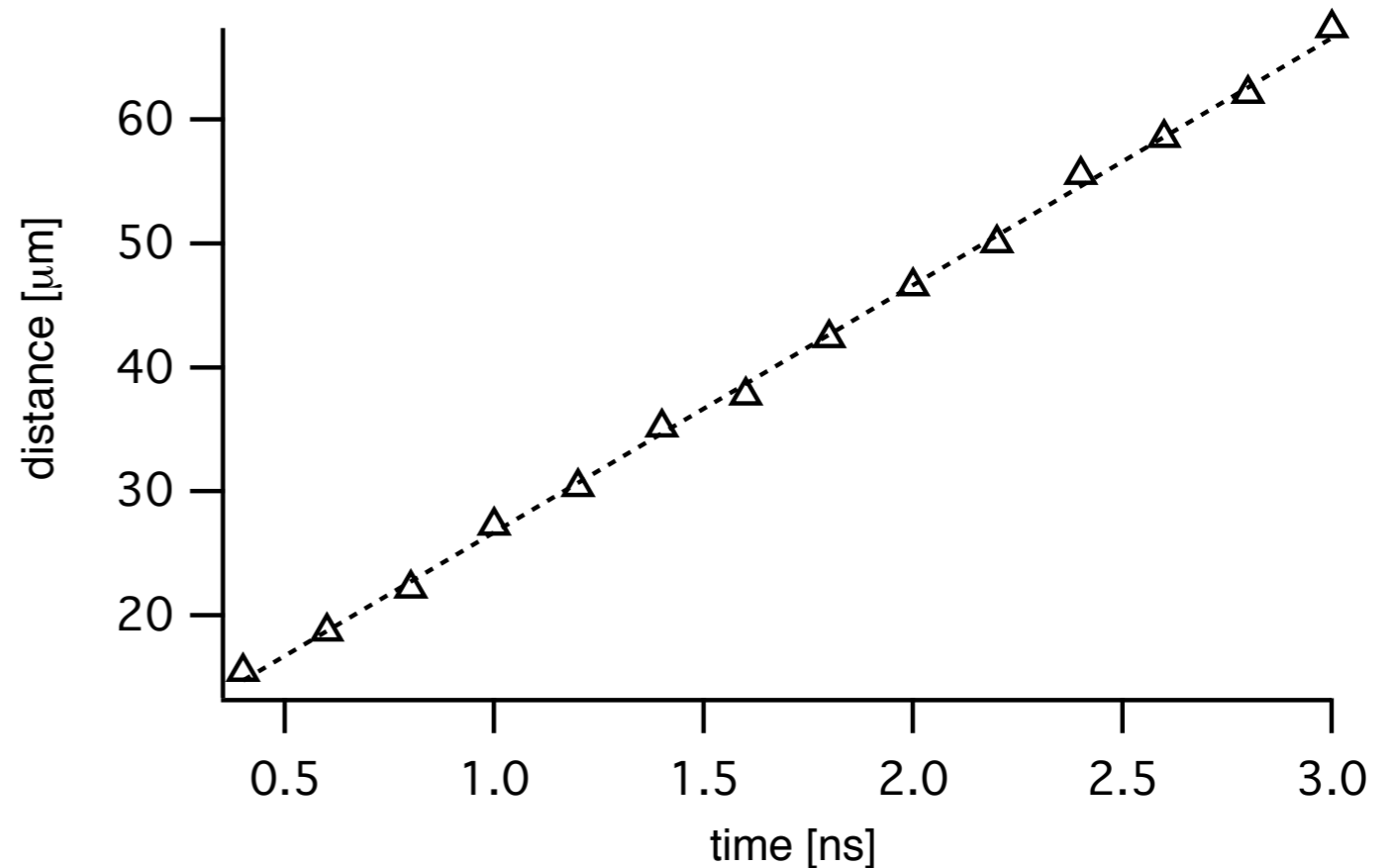
- > shock velocity
- > density distribution with both high spatial and temporal resolution



# Elastic Wave in Diamond

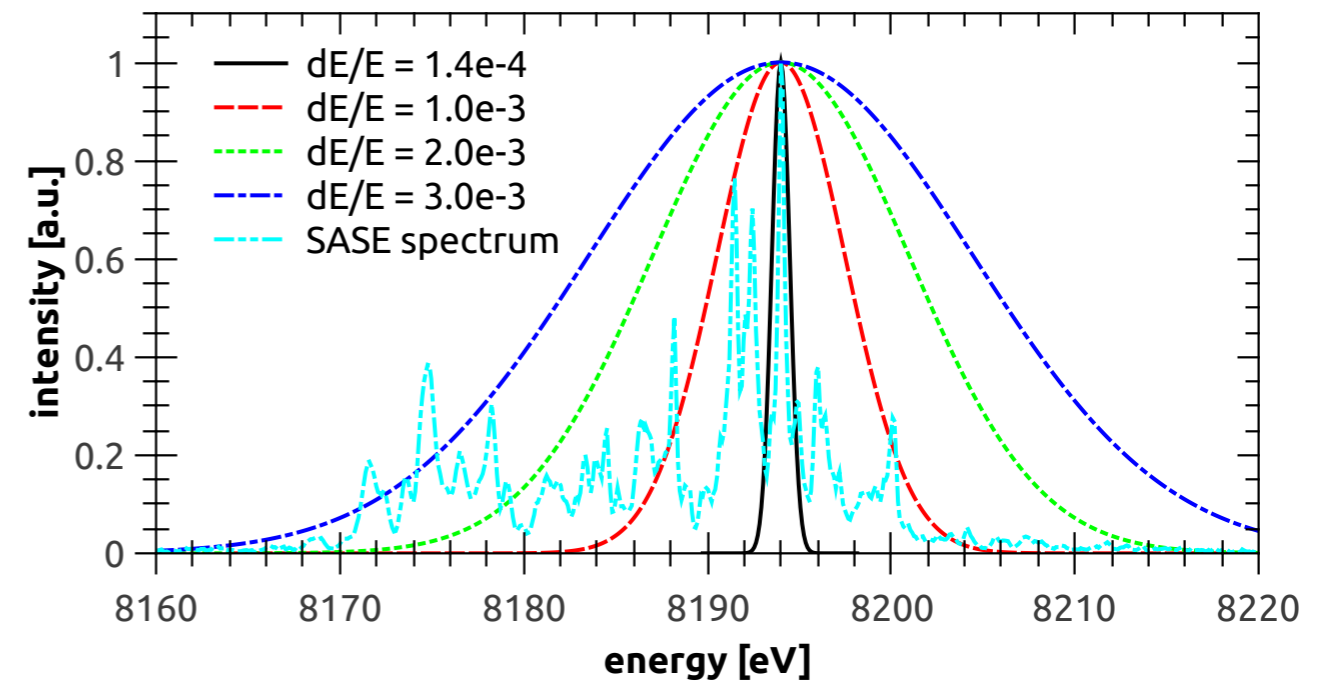
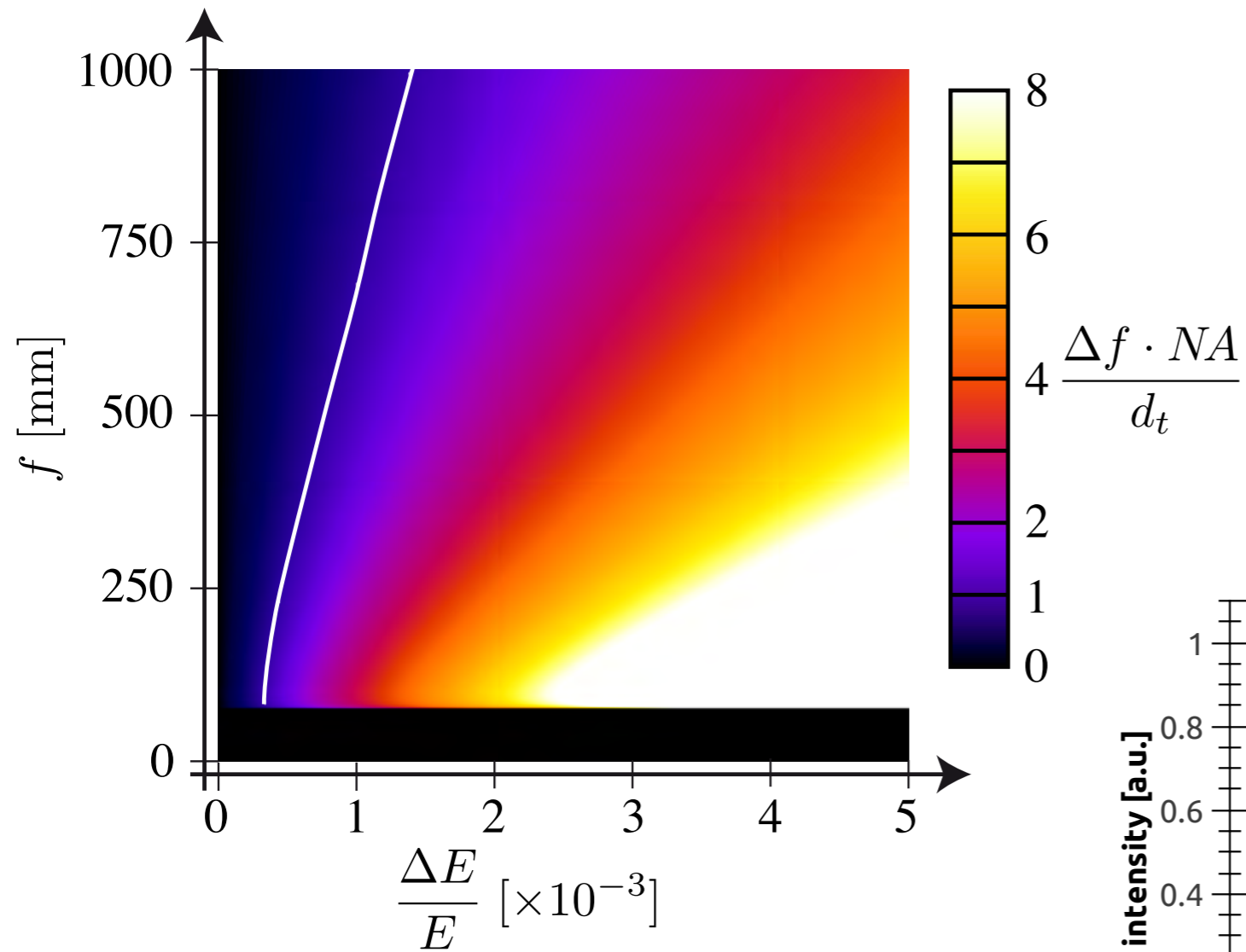
Quantitative information on

- > shock velocity
- > compression values
- > characteristic time scale of shock decay
  
- > spatial resolution of about 300nm (SASE)
- > PCI: high sensitivity of about 1% lattice compression (not visible in absorption!)



# Chromaticity

Broadening of beam relative to diffraction limit:

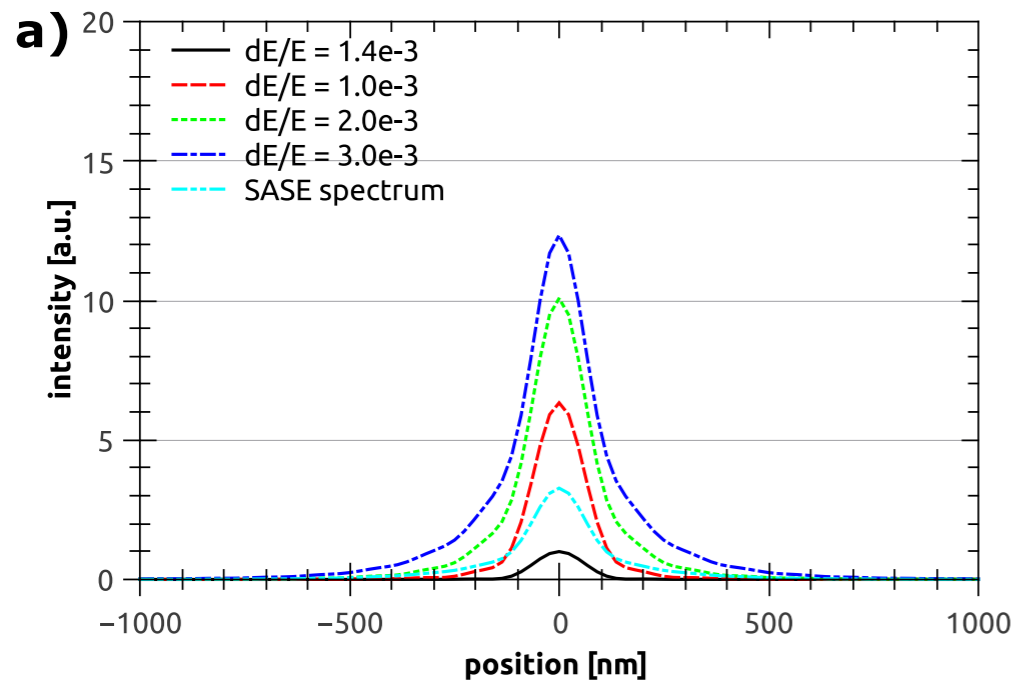


F. Seiboth, et al., J. Phys: Conf. Ser. **499**, 012004 (2014).

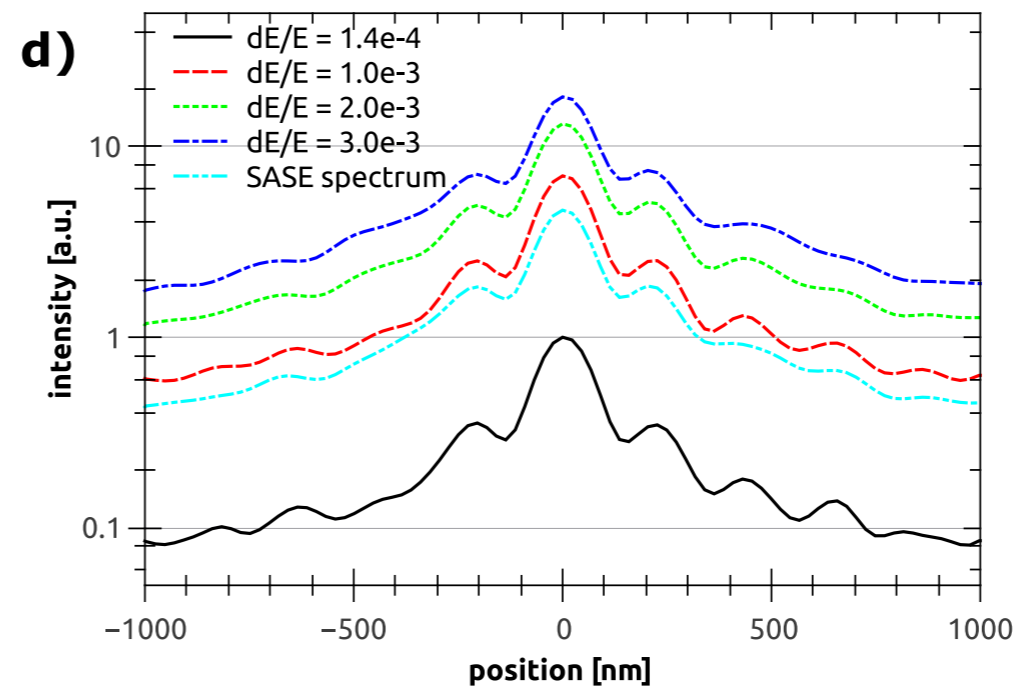
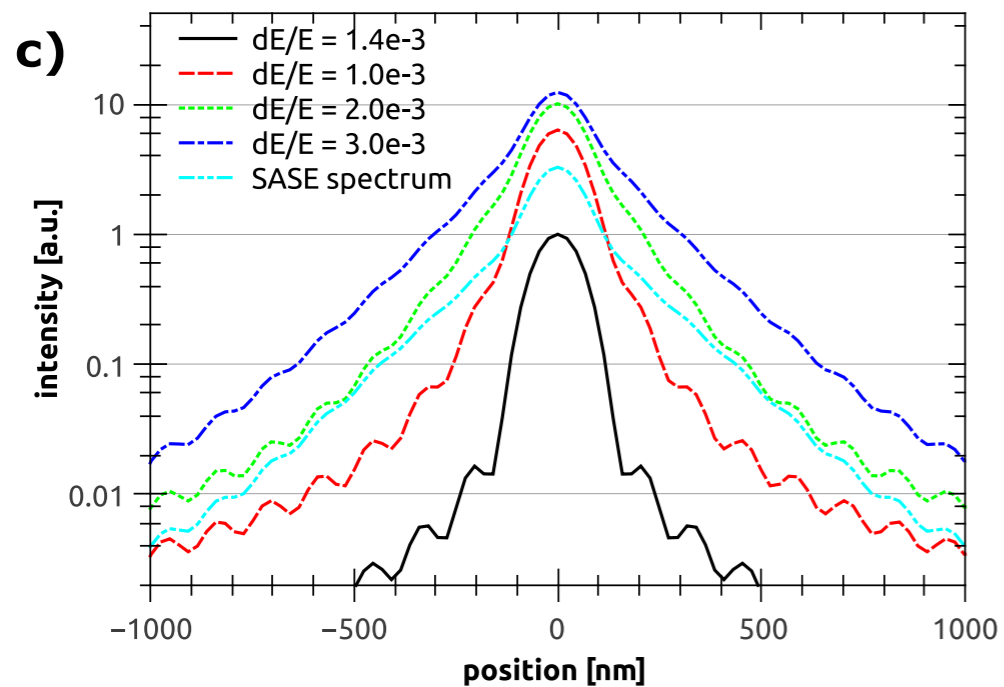
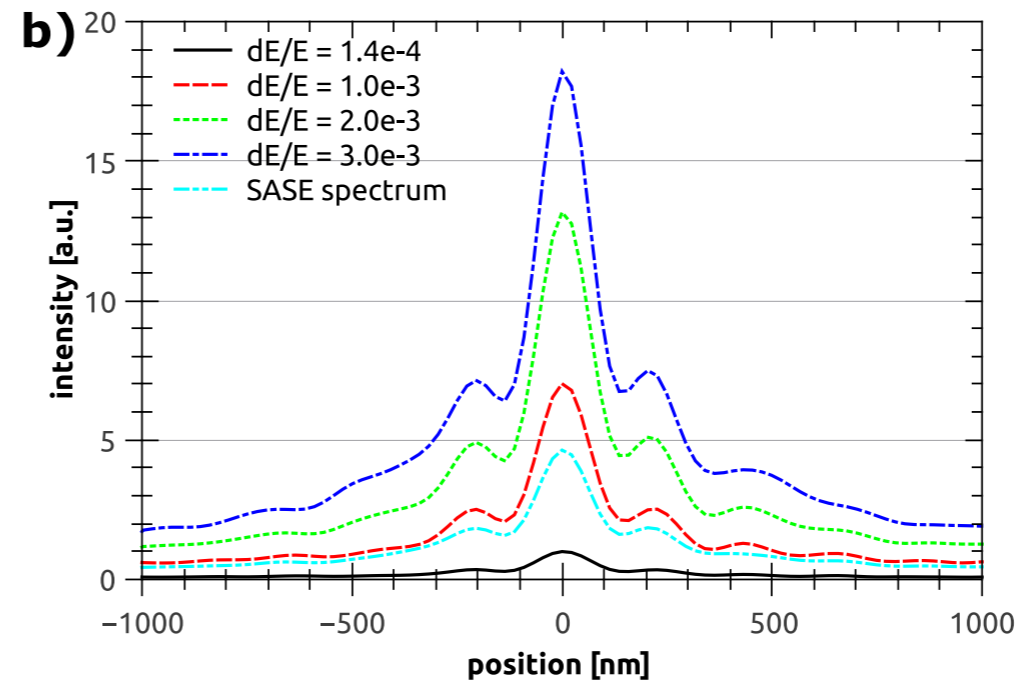


# Chromaticity and Spherical Aberration

## Ideal Gaussian Beam



## Spherical Aberration from Example

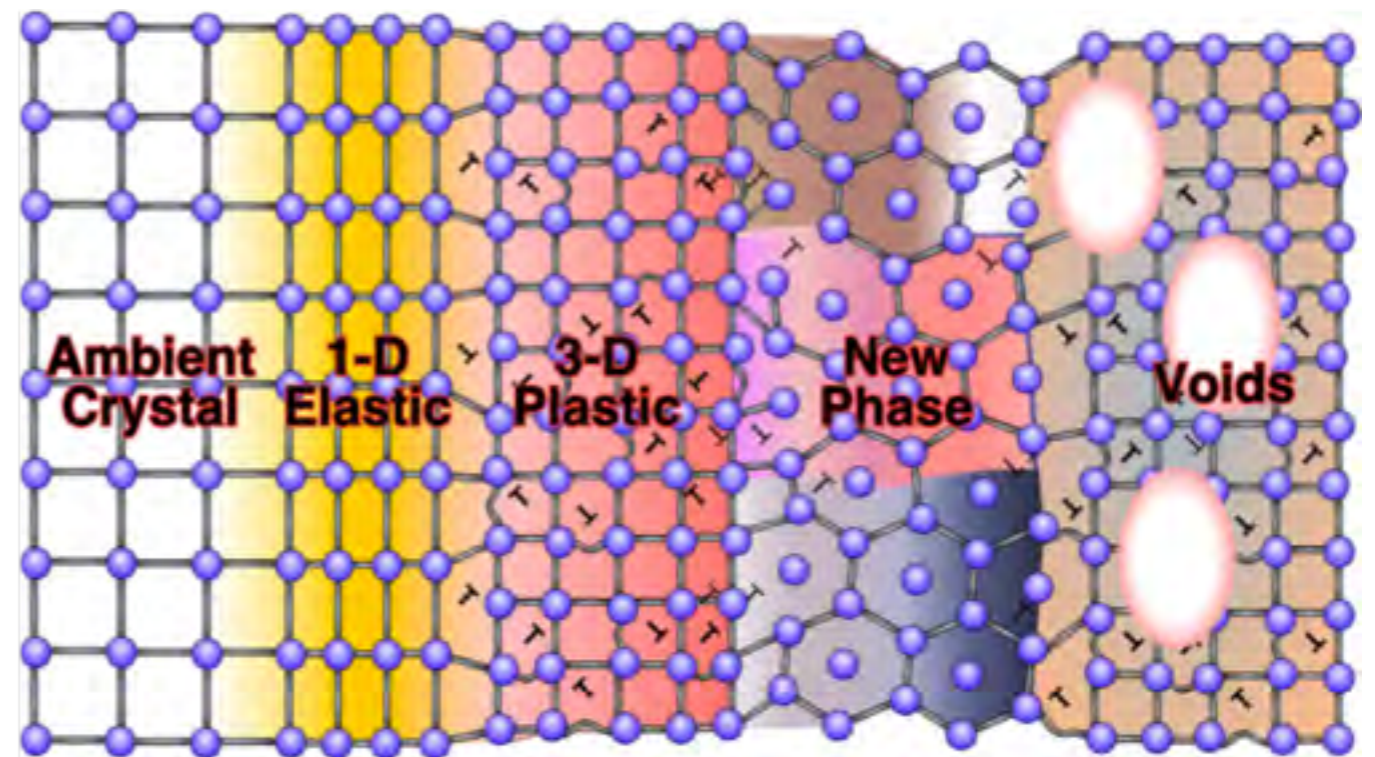


# Phase Contrast Imaging & Diffraction

## Improvements:

- > Seeded FEL: improved contrast and resolution in PCI
- > Reduced aberrations: intensive Gaussian-limited beam
- > focusing XFEL beam to  $< 100$  nm:
  - increase field of view in PCI
  - increase spatial (thus temporal) resolution in SAXS/WAXS
- > complementary diagnostics: diffraction, spectroscopy, VISAR, ...

- > structural information on the atomic scale to identify phase transformations
- > excitation states
- > small angle x-ray scattering for intermediate resolution regime covering length scales between 0.1 - 50 nm



# Research Opportunities with Nanobeams

## Imaging

- > CXDI: highest resolution requires maximal fluence (extreme focusing)
- > Near-field phase contrast imaging (with magnification):  
Intermediate resolution (e. g., down to 50 nm) with  
larger field of view (smaller beam → larger FOV)

## Time-resolved determination of structure and dynamics

- > local structure determination  
SAXS, WAXS, spectroscopies  
to avoid averaging over inhomogeneities

## Create matter in extreme conditions

- > homogeneous heating with x-rays

## Non-linear optics

- > highest intensities (multi-photon processes)

